



A unified theory of surface resistance and the residual resistance of SRF cavities at low temperatures

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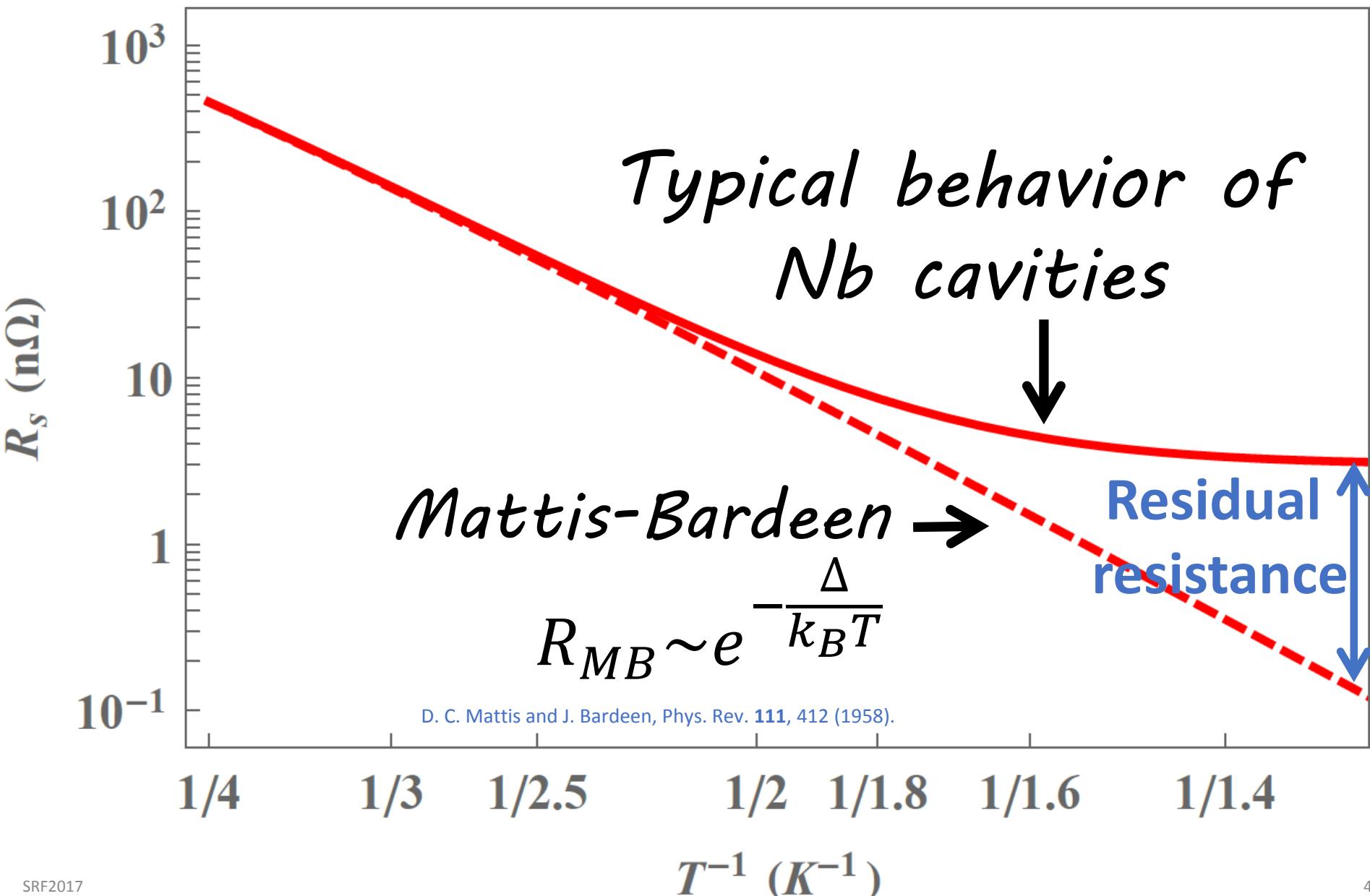


#17H04839

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Surface resistance of Nb cavity



To explain this shift,
we have summed different contributions so far

R_{MB} : Mattis-Bardeen surface resistance

R_{others} : others

Damaged layer

Metallic sub-oxide

Subgap states

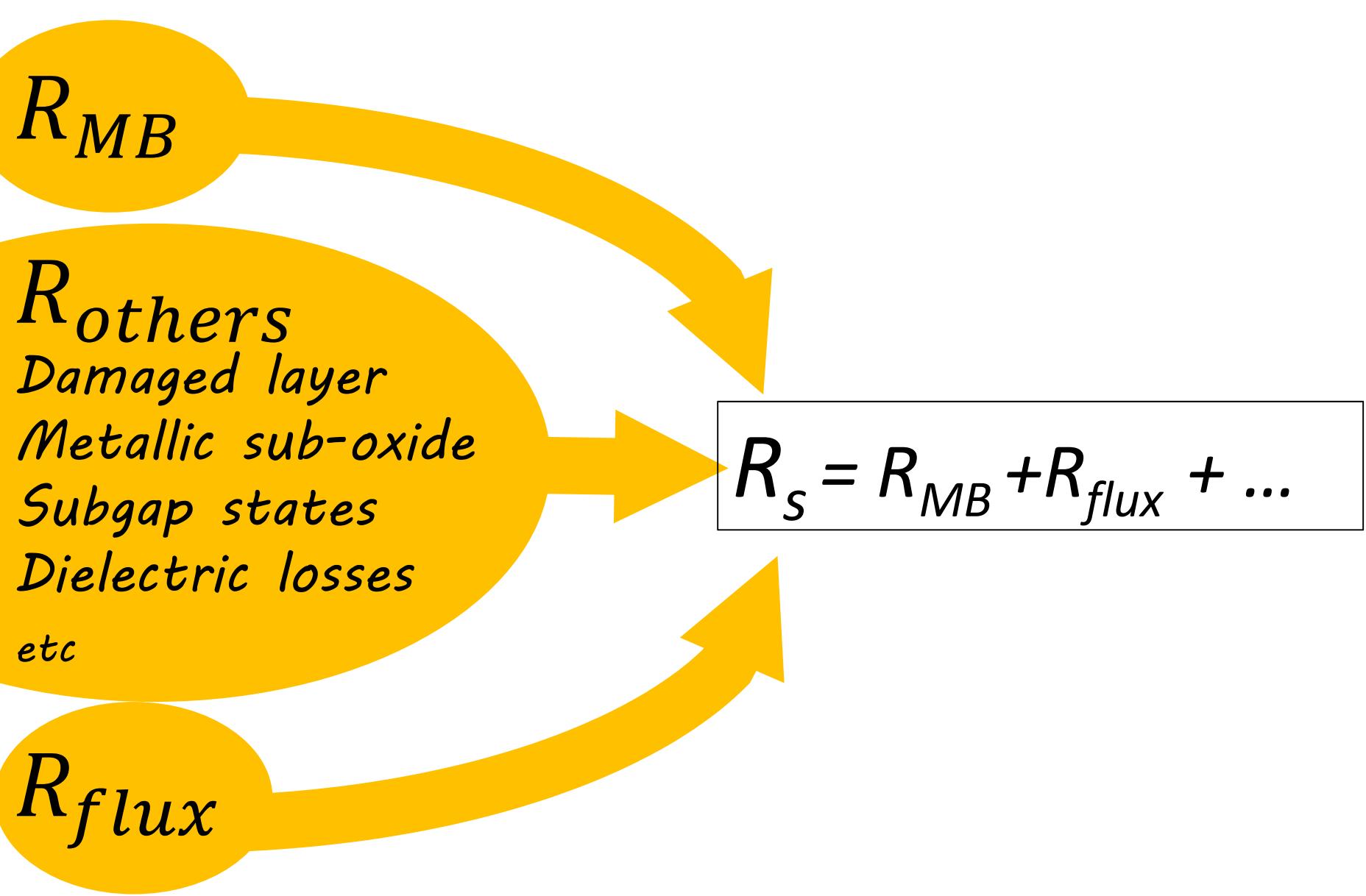
Dielectric losses

etc

R_{flux} : trapped flux contribution

A. Gurevich and G. Ciovati, Phys. Rev. B **87**, 054502 (2013).

To explain this shift,
we have summed different contributions so far



Today, R_{flux} can be substantially reduced by cooling down a cavity with a large temperature gradient.

- A. Romanenko, et al., Appl. Phys. Lett. **105**, 234103 (2014).
- S. Posen et al., J. Appl. Phys. **119**, 213903 (2016)
- S. Huang, T. Kubo, and R. Geng, Phys. Rev. Accel. Beams **19**, 082001 (2016)

R_{MB}

R_{others}

Damaged layer

Metallic sub-oxide

Subgap states

Dielectric losses

etc

$\cancel{R_{\text{flux}}}$

$$R_S = R_{MB} + \cancel{R_{\text{flux}}} + \dots$$

Today, R_{flux} can be substantially reduced by cooling down a cavity with a large temperature gradient.

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R_{MB}

R_{others}

Damaged layer

Metallic sub-oxide

Subgap states

Dielectric losses

etc

β_{flux}

$$R_s = R_{MB} + \cancel{\beta_{\text{flux}}} + \dots$$

Understanding this part
is becoming important
more and more!

In the present study, we incorporate *these effects* based on the BCS theory

R_{MB}

R_{others}

Damaged layer

Metallic sub-oxide

Subgap states

Dielectric losses

etc

R_{flux}

and obtain a theory that unifies R_{MB} and the effects of real materials.

R_{MB}

R_{others}

Damaged layer

Metallic sub-oxide

Subgap states

Dielectric losses

etc

R_{flux}

$R_{unified}$

R_S

and obtain a theory that unifies P and

It should be noted that

We do not propose
“a new BCS” or “new MB”

We do not propose
“a new model”

and obtain a theory that unifies R_{MB} and the effects of real materials.

We incorporate
the realistic surface
and bulk properties
based on the BCS theory.

R
R
D
M
S
D
et

R_{flux}

At the end of this talk we will have a unified theory, which will provide us with clues to understanding what makes the differences of the low field R_s among

- EP only
- EP + 120°C baking
- N or Ti doping
- Nitrogen infusion

Etc

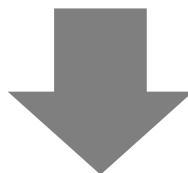
and tell us how to engineer the cavity surface to minimize R_s

Overview

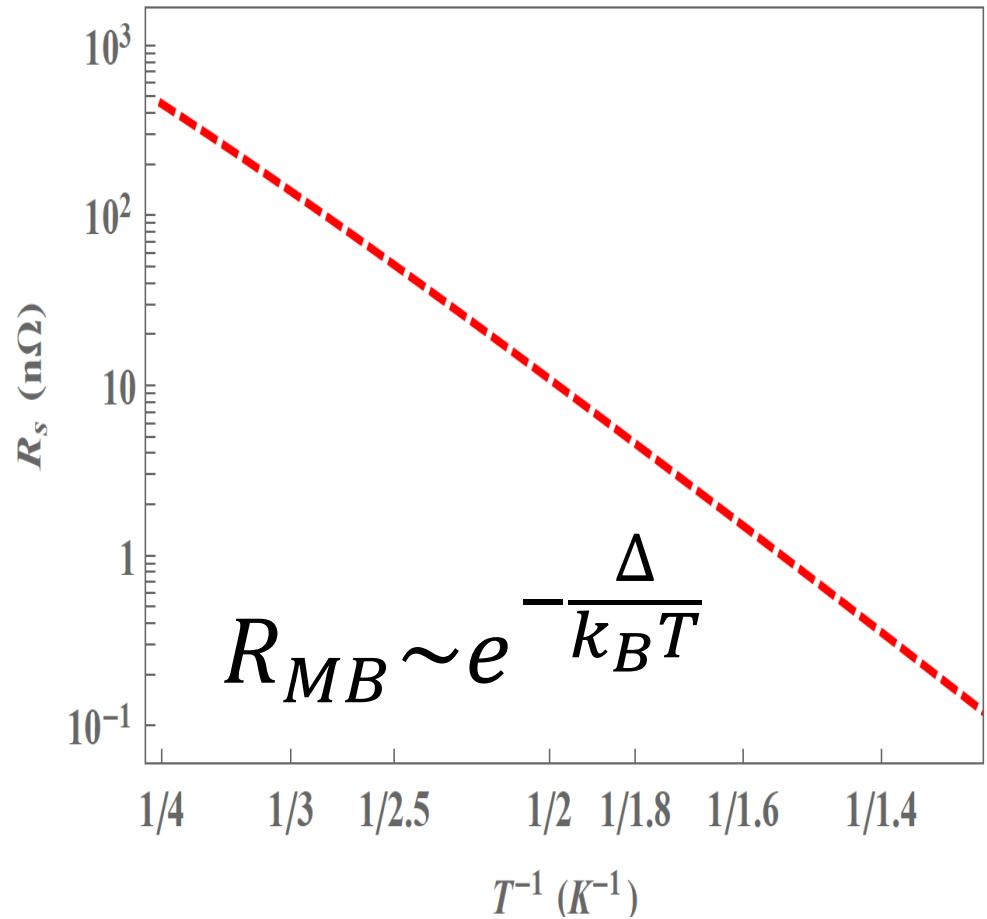
Strategy

If we start from

BCS model of
SC with an
idealized surface



Mattis-Bardeen



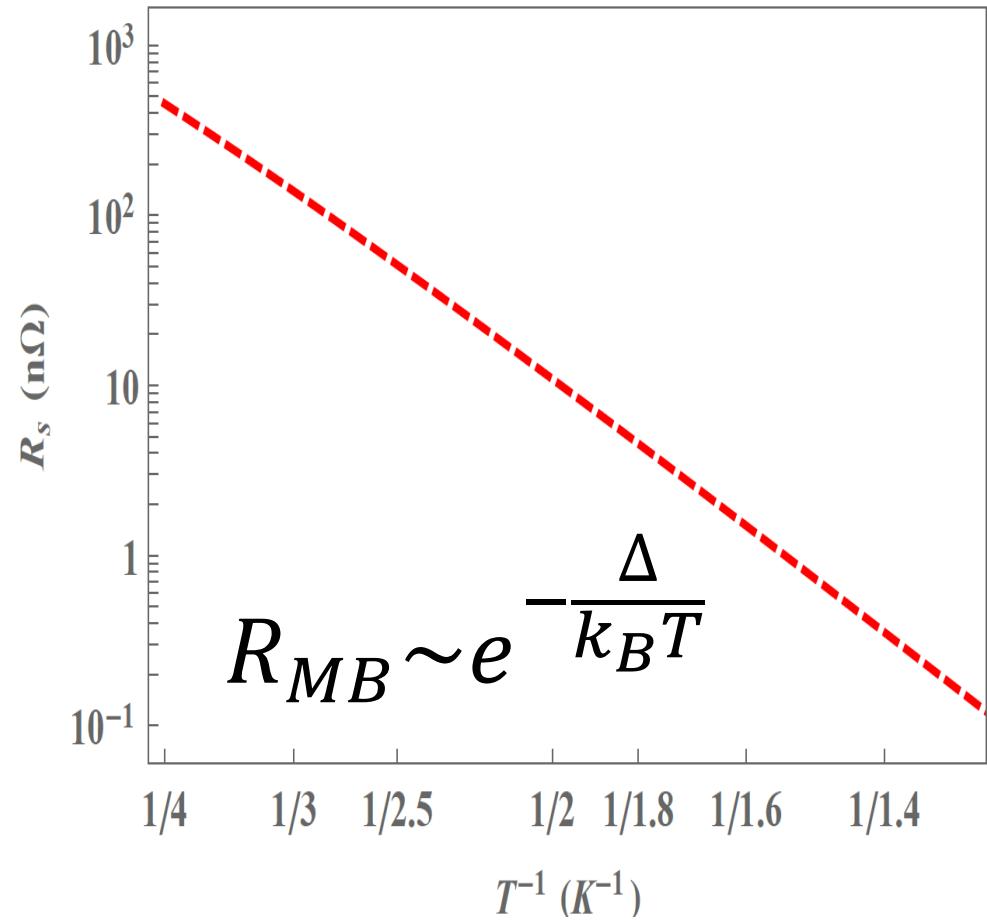
Strategy

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Mattis-Bardeen

Fails



Strategy

If we start from

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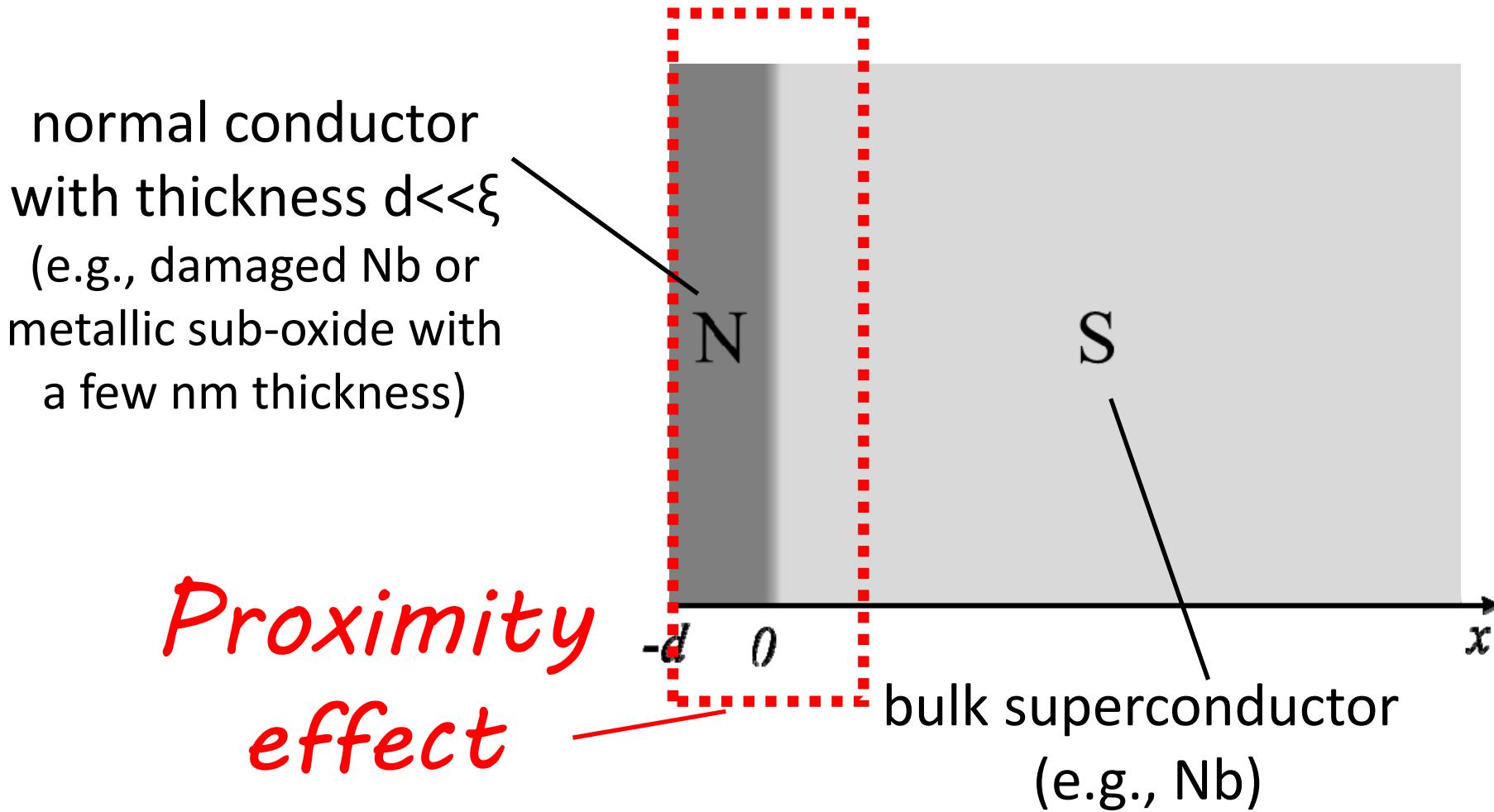
Mattis-Bardeen

Fails

We start from

**BCS model of
“a more realistic” SC**

“More realistic” SC



“More realistic” SC

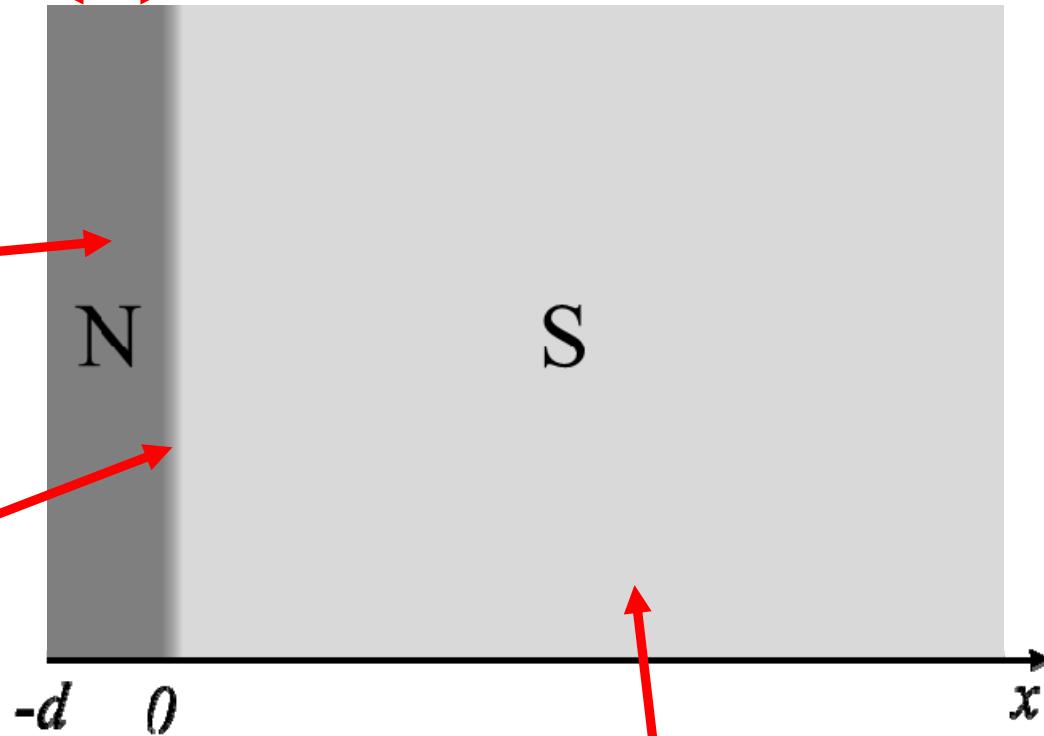
Main physical parameters of this system

Normal layer thickness

$$d$$

Normal conductance
for N layer σ_n^N

Interface
resistance R_B



Normal conductance
for bulk region σ_n^S

Theoretical tool

We use the quasiclassical theory in the diffusive limit.

- *Usadel equation* $\xi_j^2 \theta'' = -\frac{\Delta}{\Delta_\infty} \cos \theta + \frac{\hbar \omega_n}{\Delta_\infty} \sin \theta \quad \xi_j \equiv \sqrt{\hbar D_j / 2\Delta_\infty} \quad (j = N, S)$
- *Self-consistency condition* $\Delta(x) = 2\pi k_B T g(x) \sum_{\omega_n}^{\Omega} \sin \theta(x)$
- *Boundary conditions* $\theta'|_{\text{surface}} = 0, \quad \gamma_B \xi_N \theta'_- = \sin(\theta_0 - \theta_-)$
 $\theta(\infty) = \theta_\infty, \quad \gamma \xi_N \theta'_- = \xi_S \theta'_0,$

K. D. Usadel, Phys. Rev. Lett. **25**, 507 (1970).

M. Yu. Kuprianov and V. F. Lukichev, Sov. Phys. JETP **67**, 1163 (1988).

where $\gamma \equiv \sigma_n^N \xi_S / \sigma_n^S \xi_N \quad \gamma_B = \sigma_n^N R_B / \xi_N$

Normal and anomalous
Quasiclassical Matsubara Green functions $G = \cos \theta \quad F = \sin \theta$

T. Matsubara, Prog. Theor. Phys. **14**, 351 (1955).

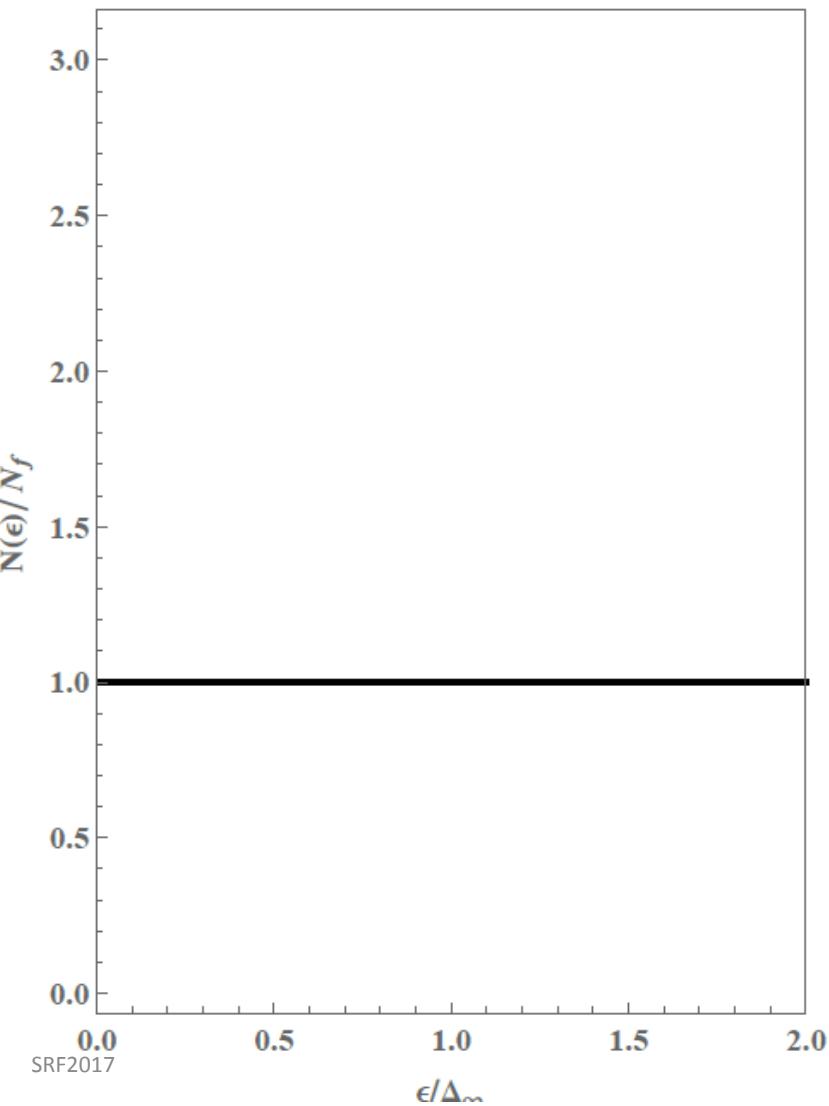
Retarded normal and anomalous
Quasiclassical Green functions $G^R = \cosh \theta \quad F^R = \sinh \theta$

Physical quantities: *Density of states and surface resistance*

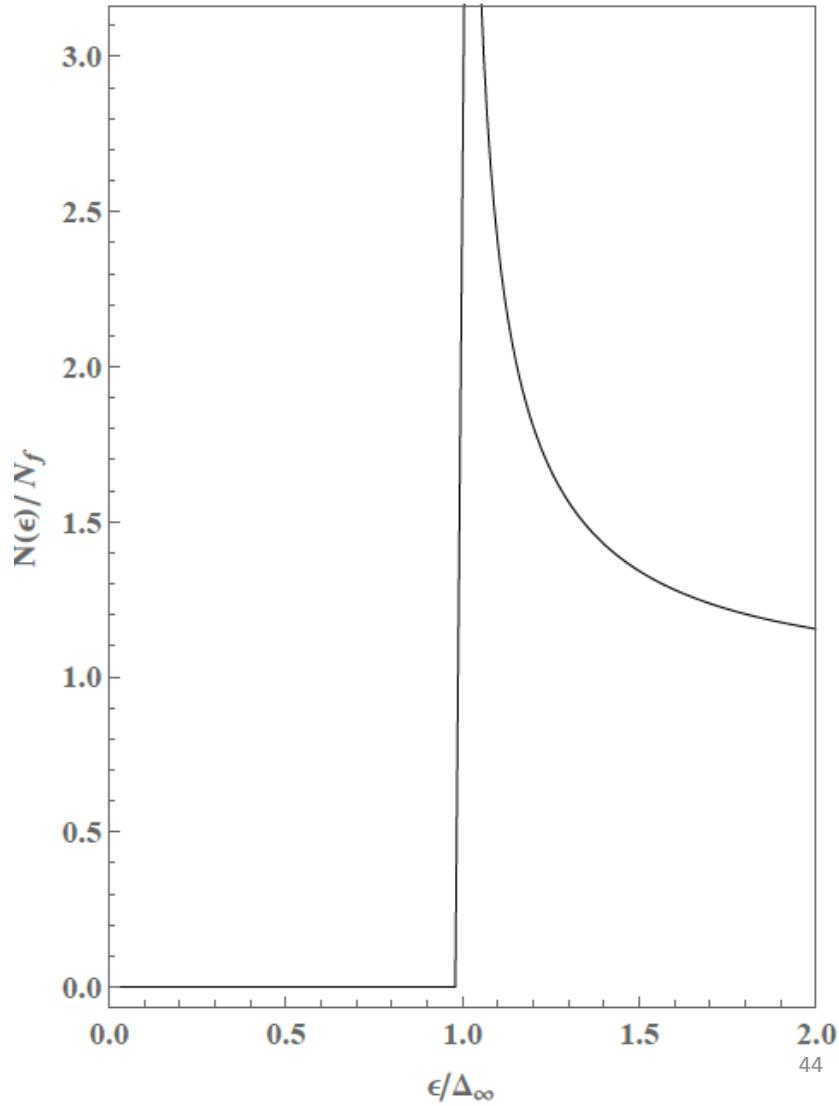
Results

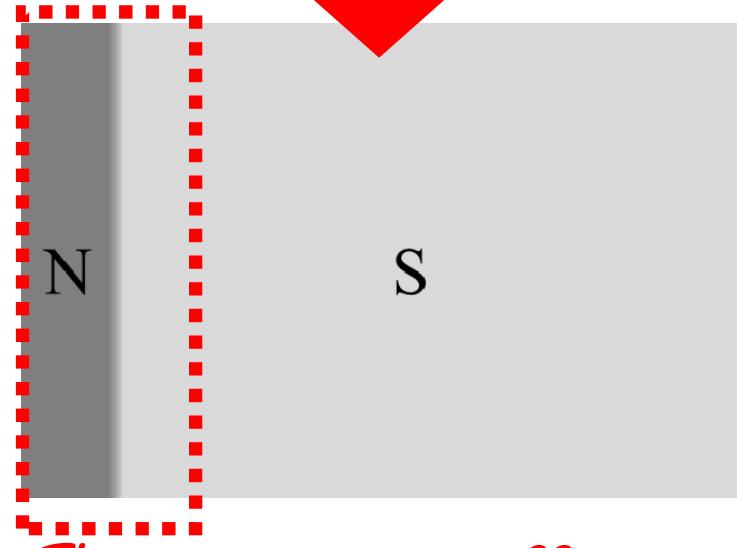
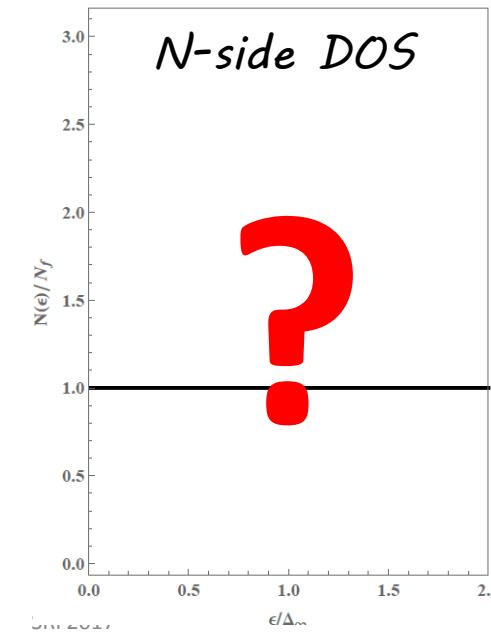
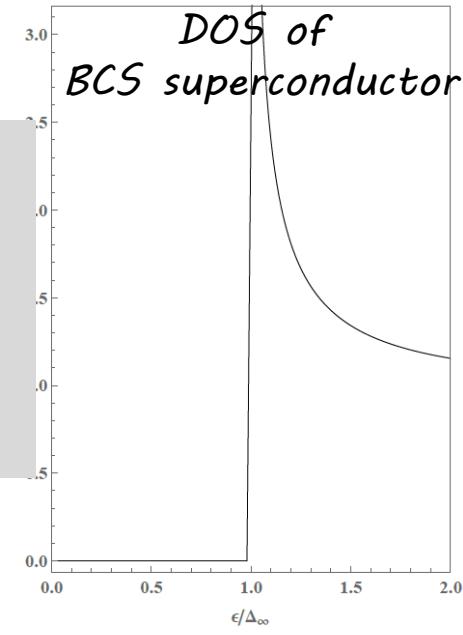
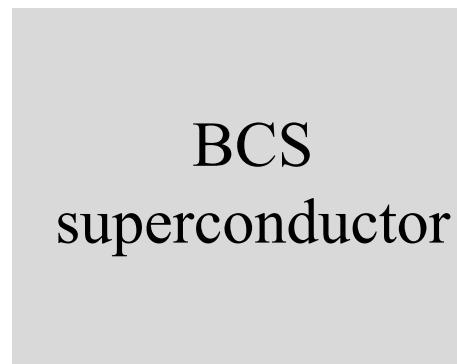
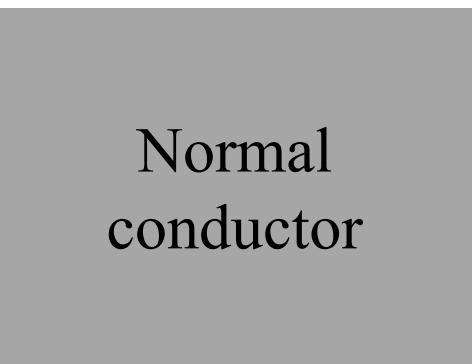
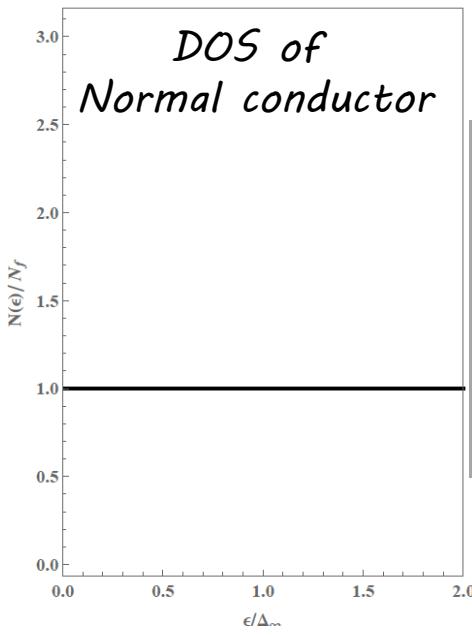
Density of states: $n=Re[G^R]$

DOS of Normal conductor

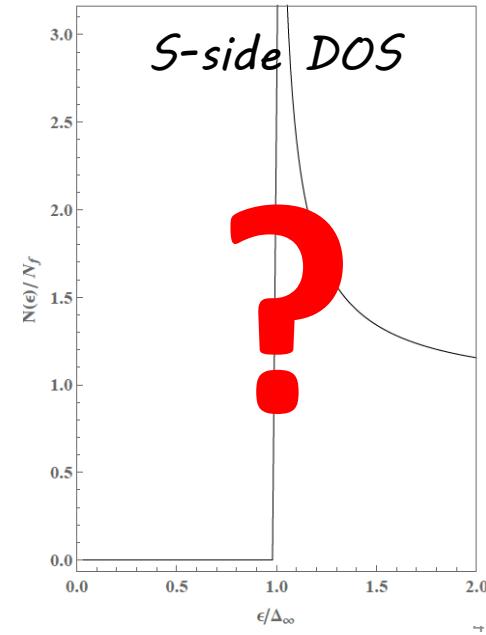


DOS of BCS superconductor





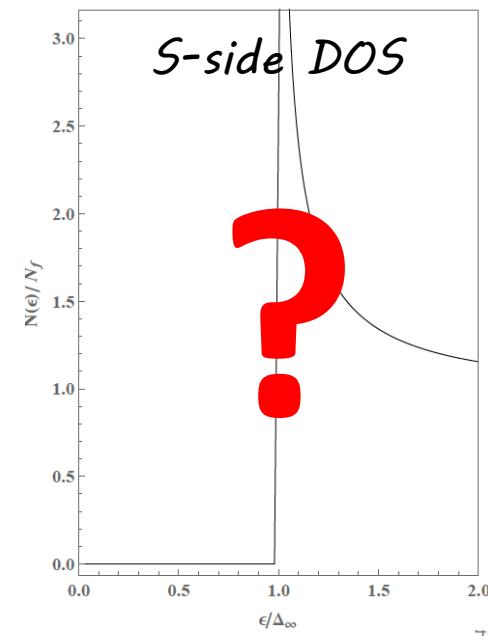
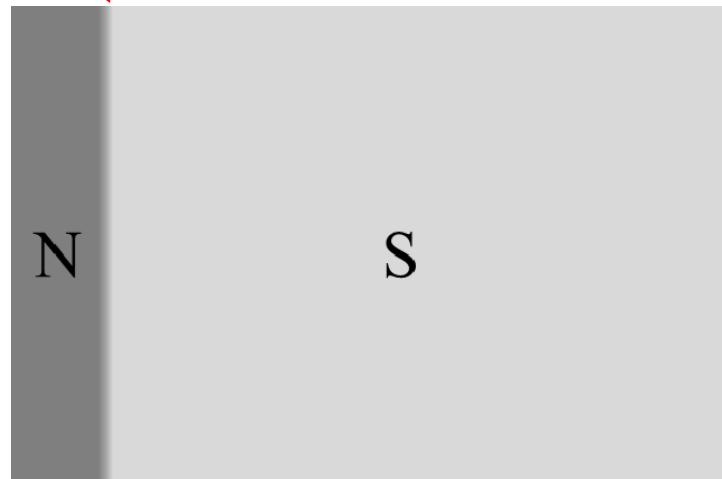
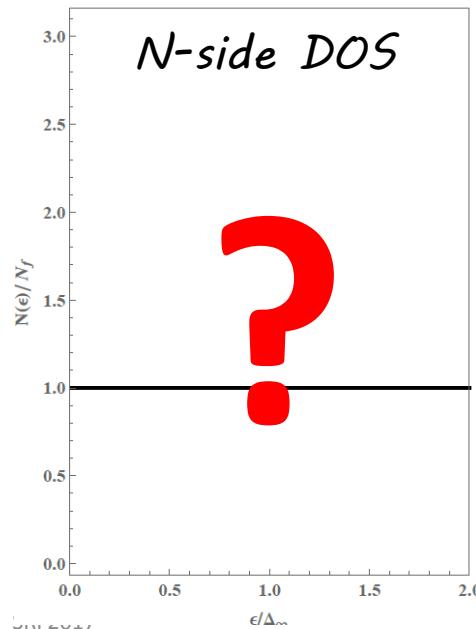
The proximity effect changes DOS



The proximity effect and resultant DOS depend on the boundary parameters

$$\alpha \equiv \gamma \frac{d}{\xi_N}$$

where $\gamma = \frac{\sigma_n^N}{\sigma_n^S} \frac{\xi_S}{\xi_N}$ is proportional to the conductance ratio between N and S.

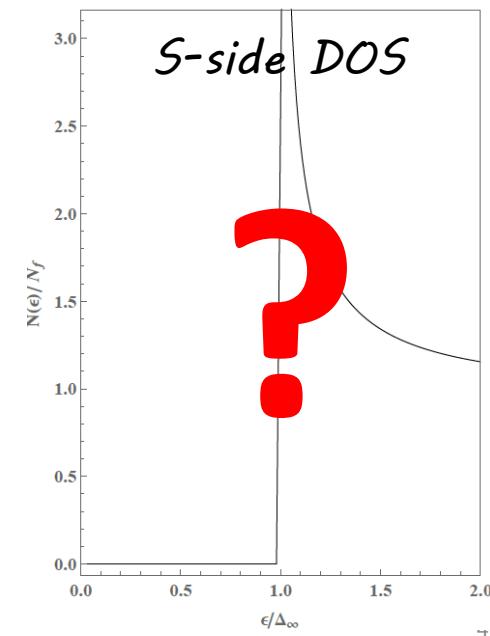
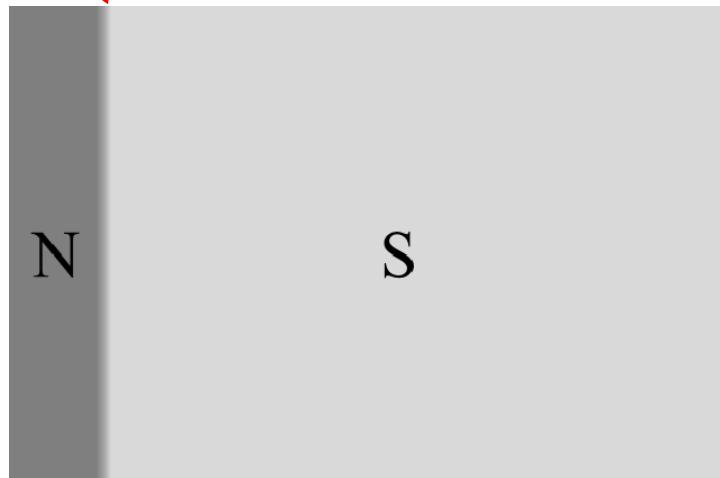
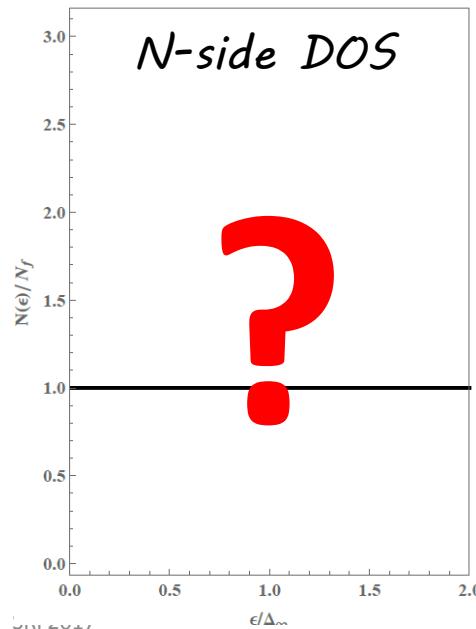


The proximity effect and resultant DOS depend on the boundary parameters

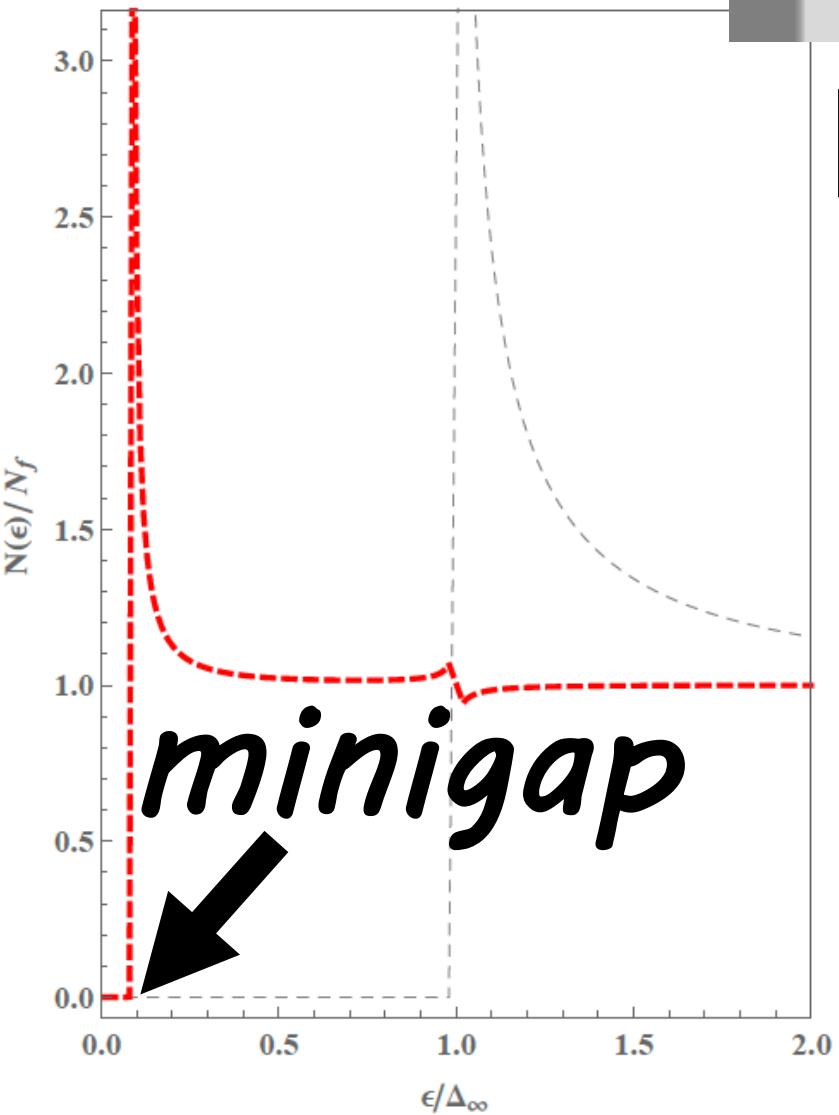
$$\beta \equiv \gamma_B \frac{d}{\xi_N}$$

where $\gamma_B = \frac{\sigma_n^N}{\xi_N} R_B$ is proportional to the interface resistance between N and S.

Barrier parameter

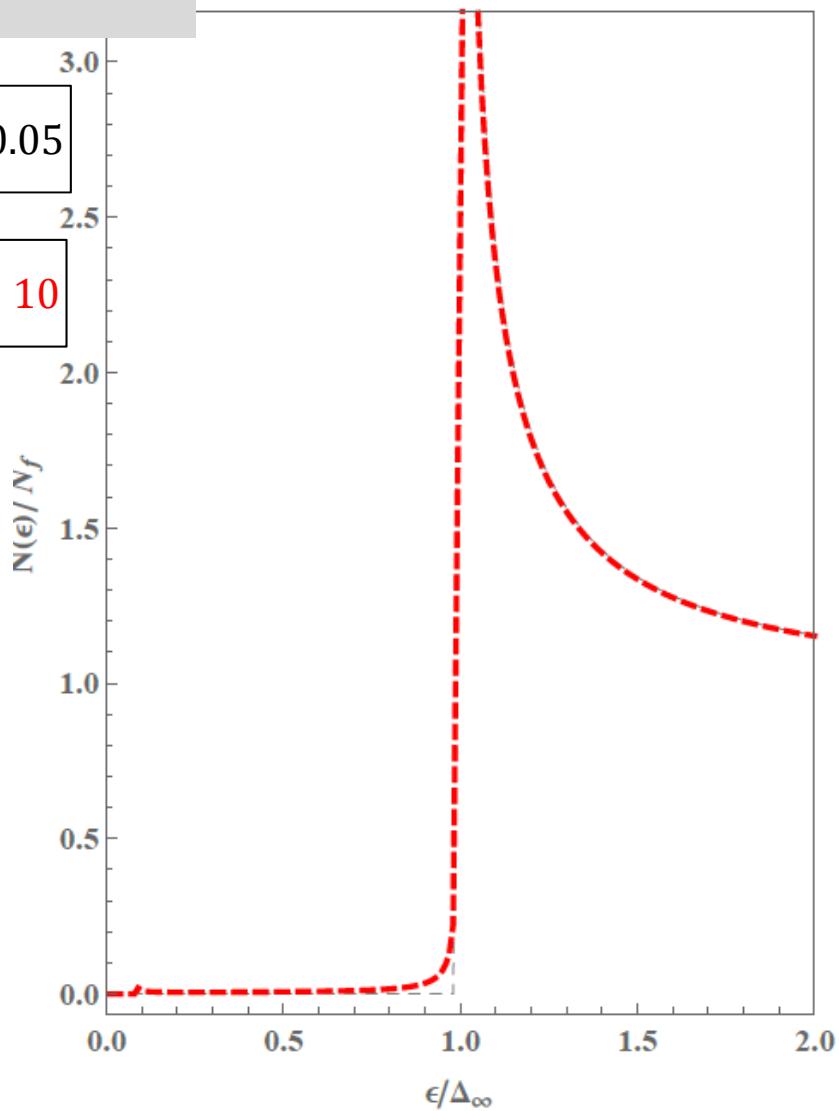


*N-side
DOS*

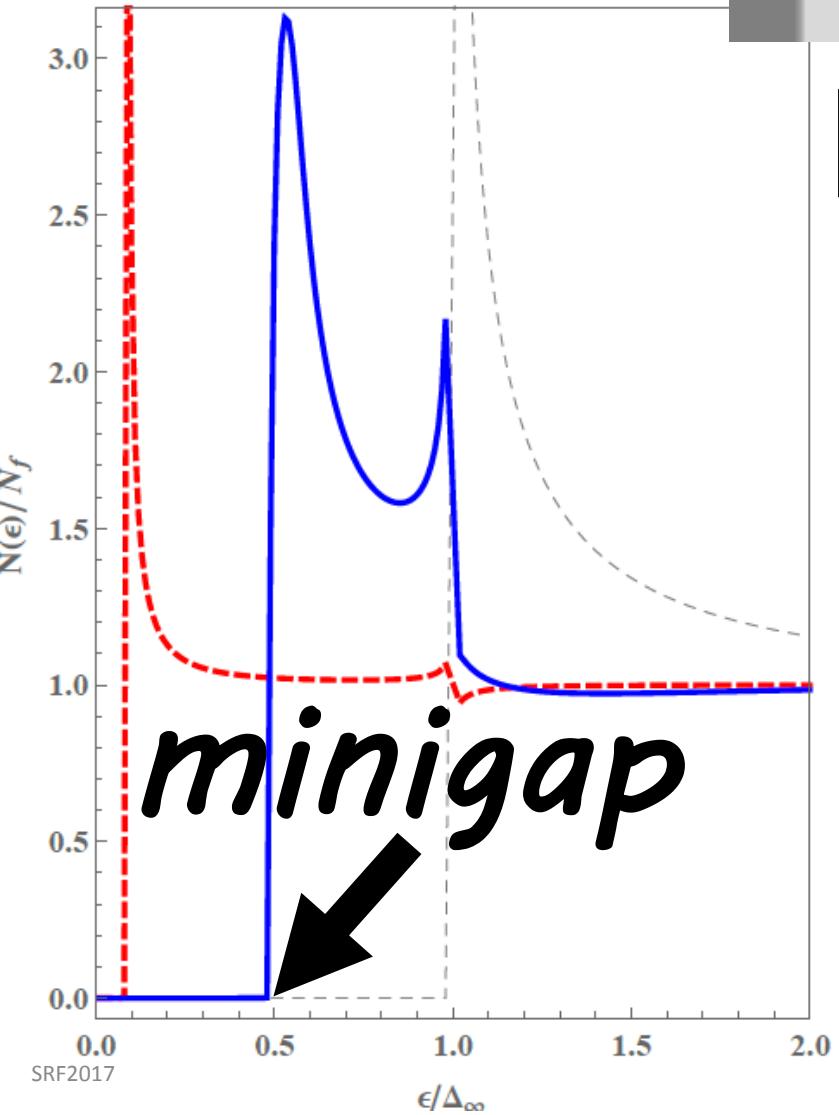


S

*S-side
DOS*

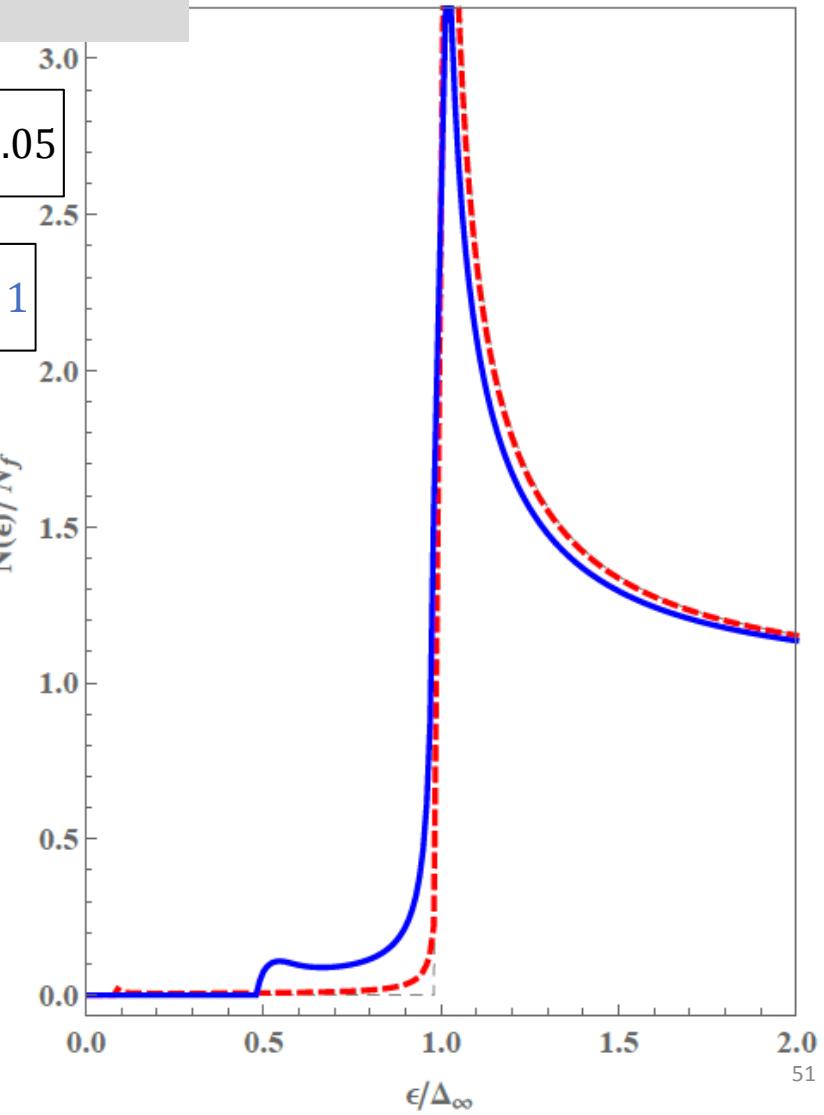


N-side DOS



S

S-side DOS



$$\alpha \equiv \gamma \frac{d}{\xi_N} = 0.05$$

$$\beta \equiv \gamma_B \frac{d}{\xi_N} = 1$$

$N(\epsilon)/N_f$

3.0

2.5

2.0

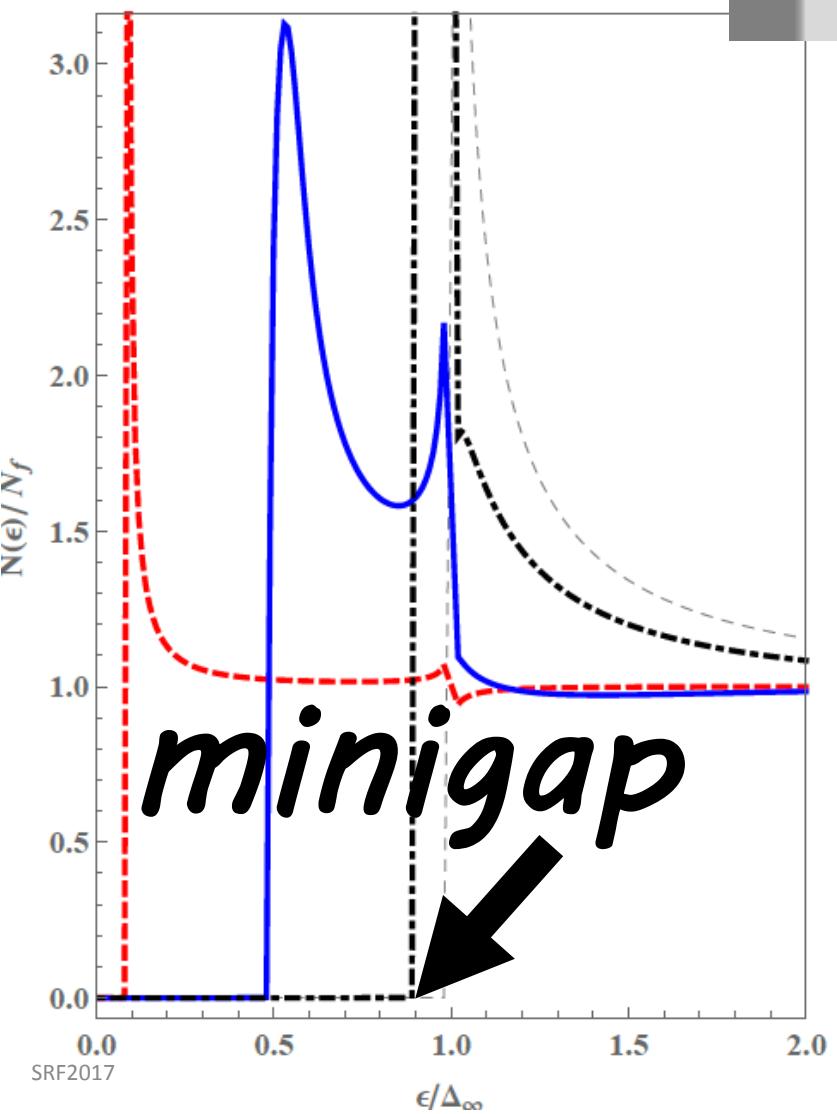
1.5

1.0

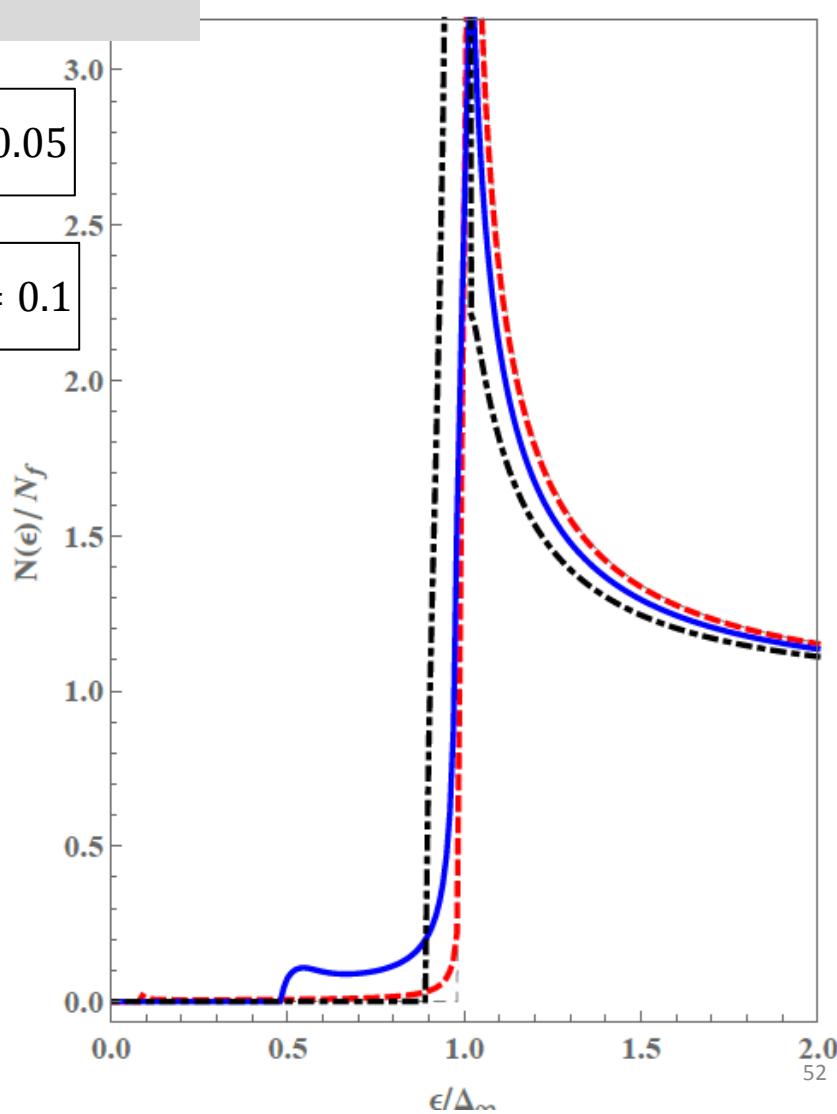
0.5

0.0

N-side DOS

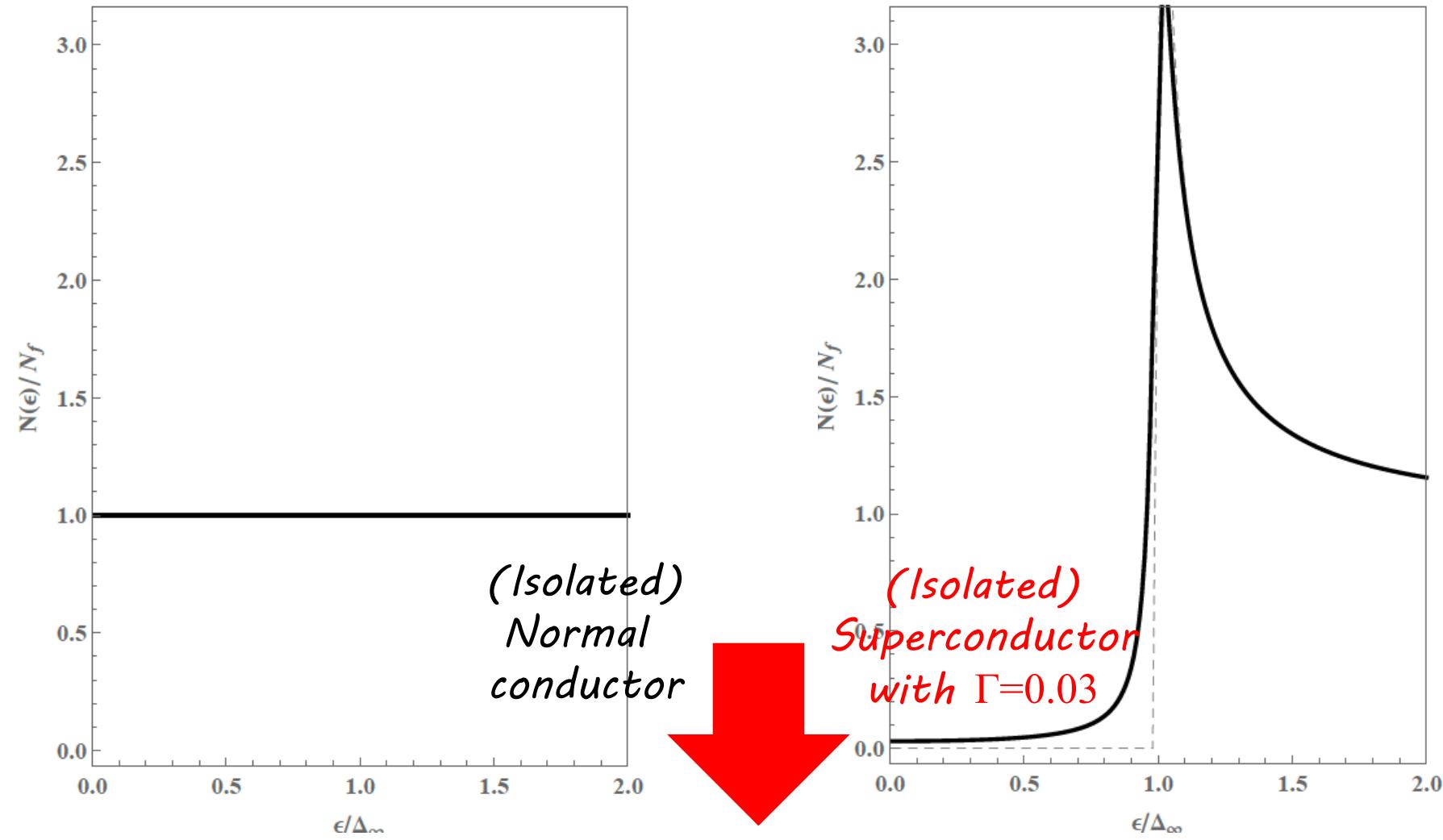


S-side DOS

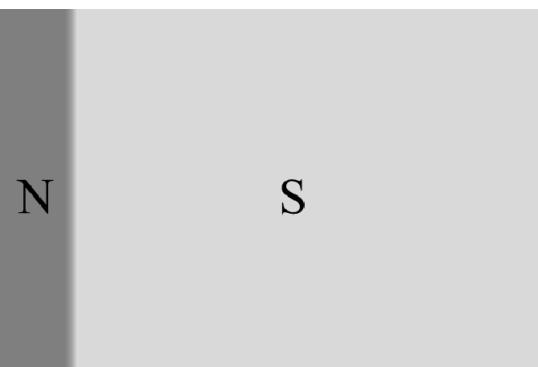
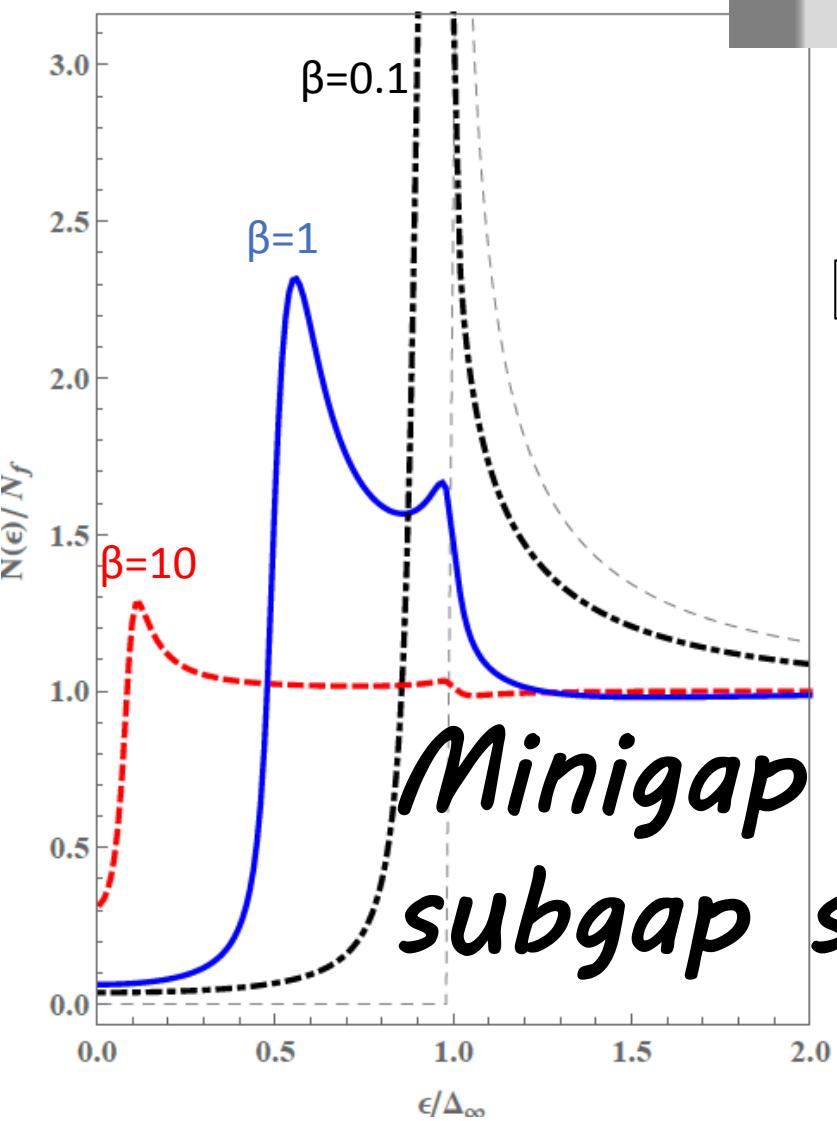


So far, in order to explicitly show the proximity effect and resultant minigap, we have neglected the bulk DOS broadening (due to an inelastic scattering, magnetic impurities, random inhomogeneities of the BCS pairing constant etc): $\Gamma=0$.

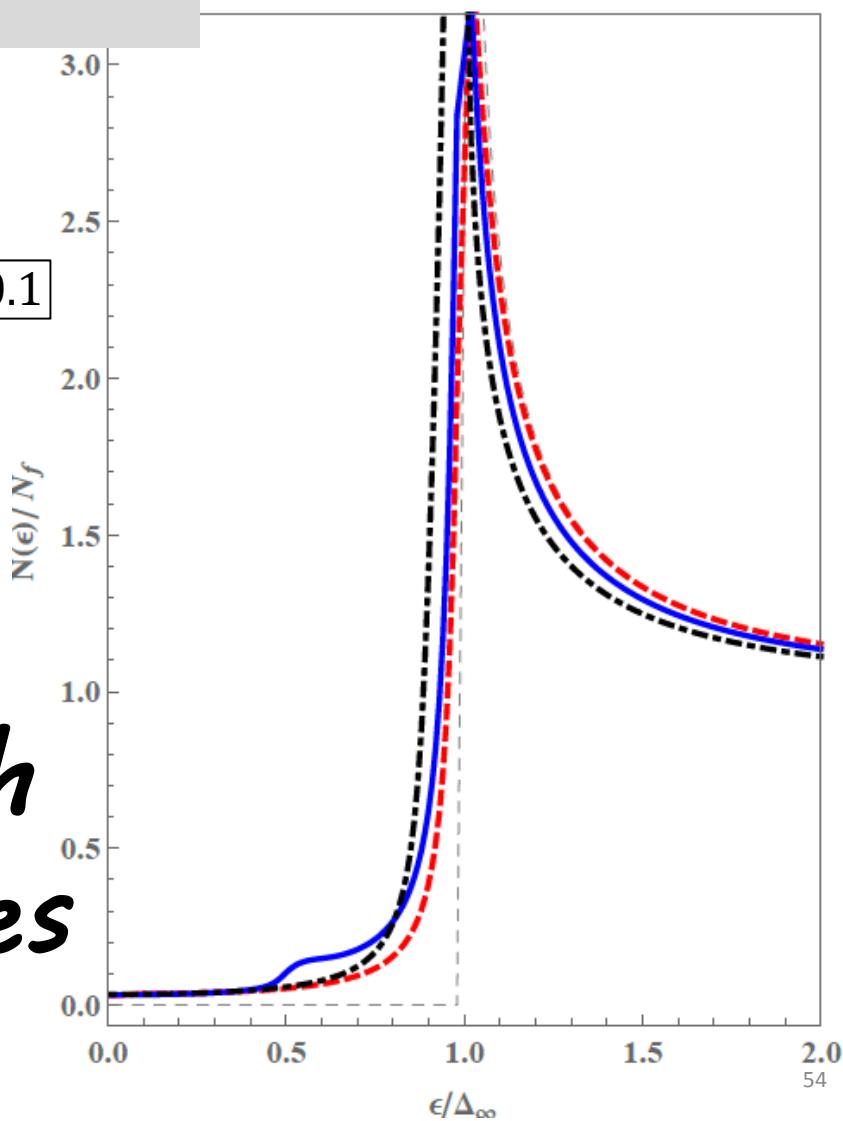
Now we incorporate a finite Γ .



*N-side
DOS*



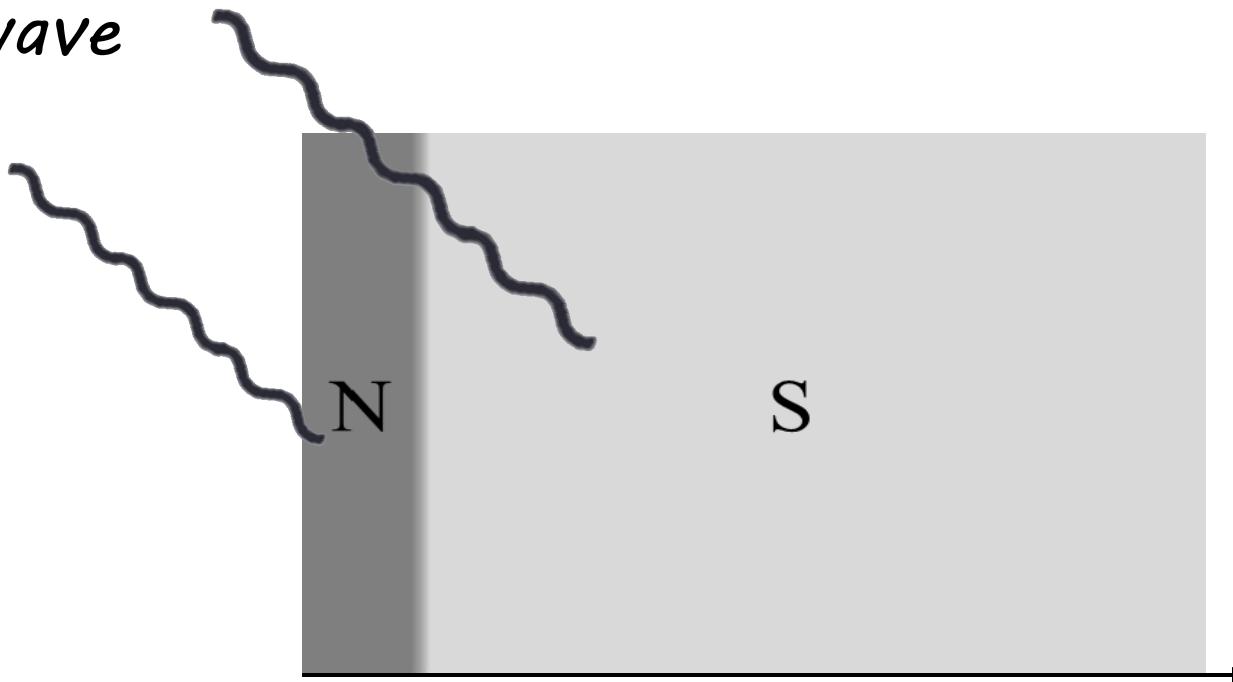
*S-side
DOS*



Surface resistance

Now we can calculate the surface resistance of the proximity coupled NS system taking the minigap induced at the N layer into account.

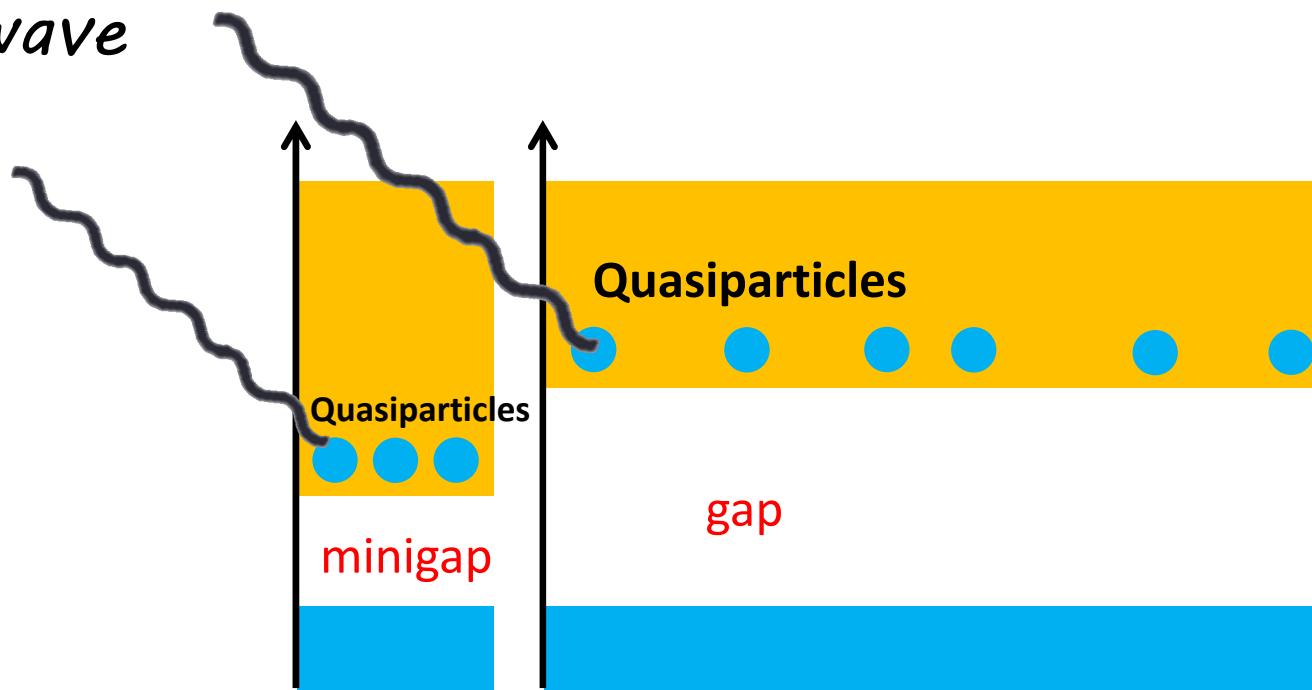
microwave



Surface resistance

Now we can calculate the surface resistance of the proximity coupled NS system taking the minigap induced at the N layer into account.

microwave



Surface resistance

General formula

$$R_s = \frac{1}{2} \mu_0^2 \omega^2 \lambda^3 \sigma_n^S (I_N + I_S)$$

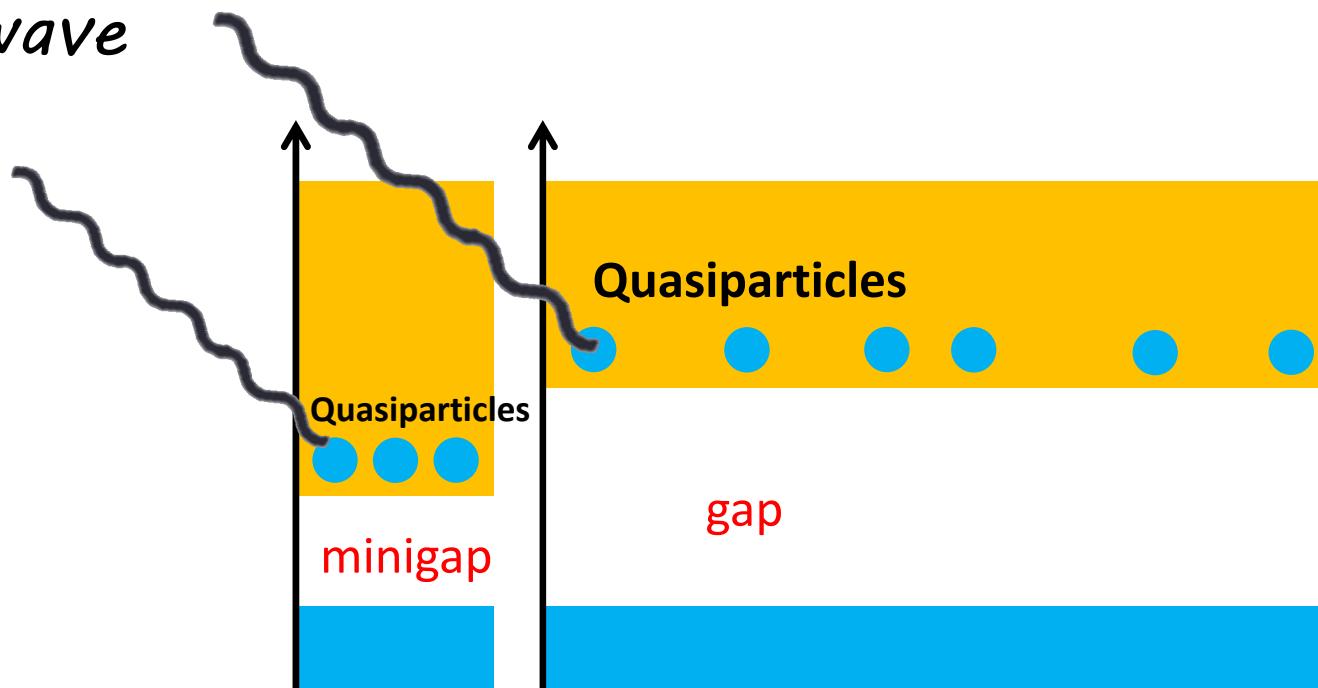
$$I_N = \frac{4}{u\lambda} \frac{\sigma_n^N}{\sigma_n^S} \int_0^\infty d\epsilon [f(\epsilon) - f(\epsilon + u)] \\ \times \int_{-d}^0 dx [n(\epsilon, x)n(\epsilon + u, x) + m(\epsilon, x)m(\epsilon + u, x)]$$

$$I_S = \frac{4}{u\lambda} \int_0^\infty d\epsilon [f(\epsilon) - f(\epsilon + u)] \\ \times \int_0^\infty dx [n(\epsilon, x)n(\epsilon + u, x) + m(\epsilon, x)m(\epsilon + u, x)] e^{-\frac{2x}{\lambda}}$$

A. Gurevich, Phys. Rev. Lett.

A. Gurevich, Supercond. Sci. Technol. **30**, 034004 (2017).

microwave



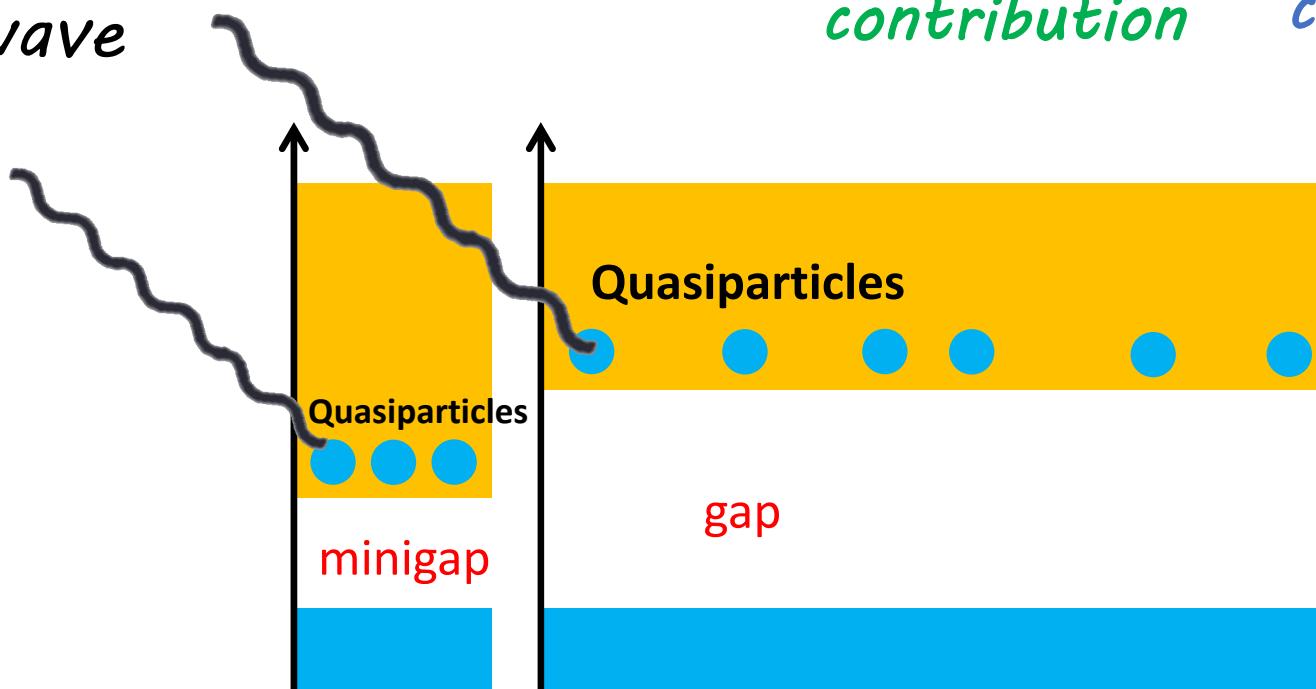
Surface resistance

Approximate formula
(for $\alpha \ll 1$ and $\Gamma \rightarrow 0$)

$$R_s = \frac{1}{2} \mu_0^2 \omega^2 \lambda^3 \sigma_n^S \frac{2\Delta_\infty}{k_B T} \ln \frac{4k_B T}{\hbar \omega e^{\gamma_E}} \left(\frac{2d}{\lambda} \frac{\sigma_n^N}{\sigma_n^S} g(\beta) e^{-\frac{\epsilon_0}{k_B T}} + e^{-\frac{\Delta_\infty}{k_B T}} \right)$$

N layer contribution *Bulk S contribution*

microwave



$$g(\beta) = \frac{1}{2\epsilon_0} \frac{1 + \epsilon_0^2(1 + \beta\sqrt{1 - \epsilon_0^2})^2}{1 + \beta^2 - 2\beta^2\epsilon_0^2 + 2\beta\sqrt{1 - \epsilon_0^2} - \frac{\beta\epsilon_0^2}{\sqrt{1 - \epsilon_0^2}}}$$

Surface resistance

Approximate formula
(for $\alpha \ll 1$ and $\Gamma \rightarrow 0$)

$$R_s = \frac{1}{2} \mu_0^2 \omega^2 \lambda^3 \sigma_n^S \frac{2\Delta_\infty}{k_B T} \ln \frac{4k_B T}{\hbar \omega e^{\gamma_E}} \left(\frac{2d}{\lambda} \frac{\sigma_n^N}{\sigma_n^S} g(\beta) e^{-\frac{\epsilon_0}{k_B T}} + e^{-\frac{\Delta_\infty}{k_B T}} \right)$$

N layer contribution *Bulk S contribution*

$$g(\beta) = \frac{1}{2\epsilon_0} \frac{1 + \epsilon_0^2(1 + \beta\sqrt{1 - \epsilon_0^2})^2}{1 + \beta^2 - 2\beta^2\epsilon_0^2 + 2\beta\sqrt{1 - \epsilon_0^2} - \frac{\beta\epsilon_0^2}{\sqrt{1 - \epsilon_0^2}}}$$

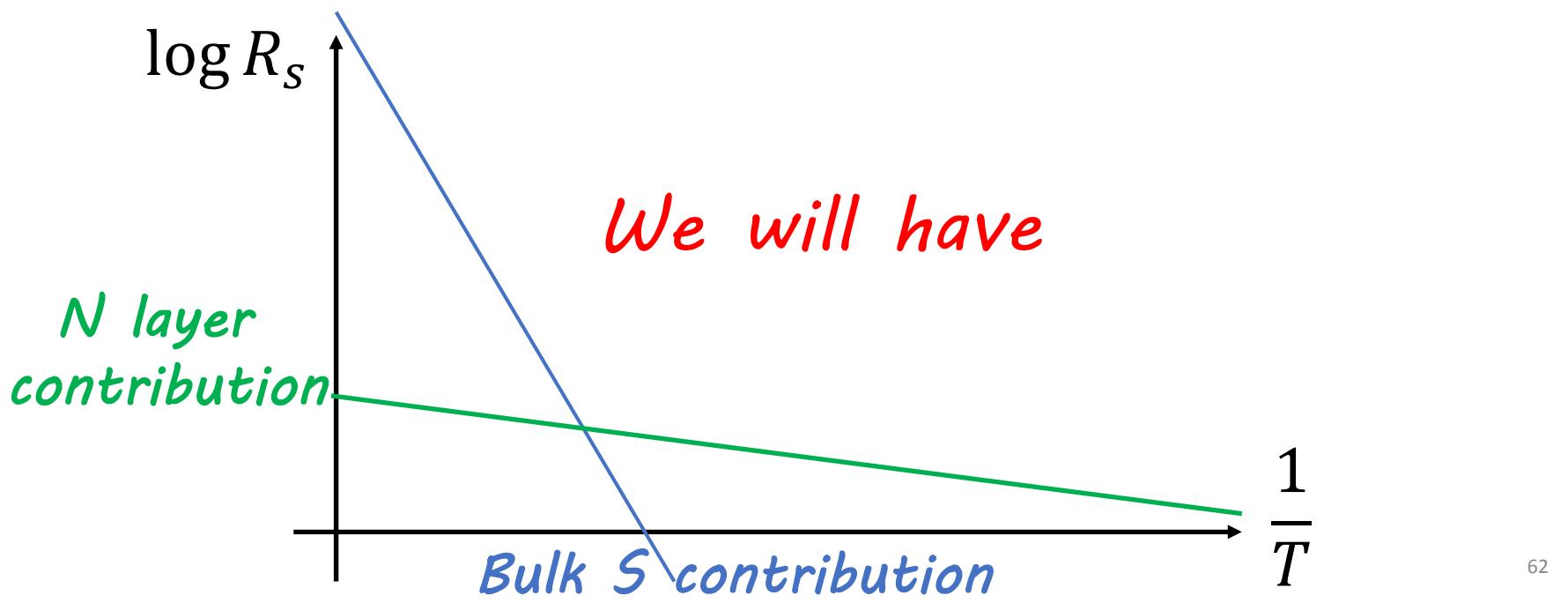
1. The **first** term is tiny due to its small thickness and small normal-conductivity.
2. As T decreases, the **second** term decreases rapidly rather than the **first** term due to its large gap.
3. At a low temperature, the **first** term becomes dominant, which looks like the residual resistance.

Surface resistance

Approximate formula
(for $\alpha \ll 1$ and $\Gamma \rightarrow 0$)

$$R_s = \frac{1}{2} \mu_0^2 \omega^2 \lambda^3 \sigma_n^S \frac{2\Delta_\infty}{k_B T} \ln \frac{4k_B T}{\hbar \omega e^{\gamma_E}} \left(\boxed{\frac{2d}{\lambda} \frac{\sigma_n^N}{\sigma_n^S} g(\beta) e^{-\frac{\epsilon_0}{k_B T}}} + \boxed{e^{-\frac{\Delta_\infty}{k_B T}}} \right)$$

N layer contribution *Bulk S contribution*

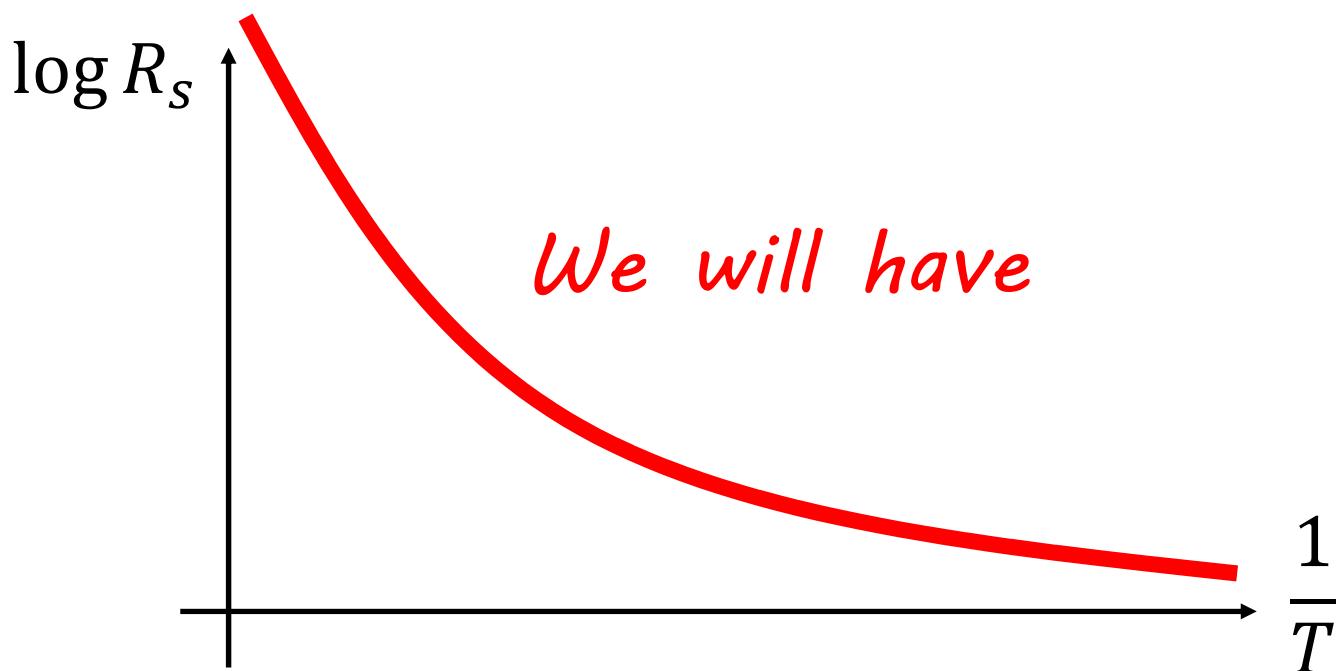


Surface resistance

Approximate formula
(for $\alpha \ll 1$ and $\Gamma \rightarrow 0$)

$$R_s = \frac{1}{2} \mu_0^2 \omega^2 \lambda^3 \sigma_n^S \frac{2\Delta_\infty}{k_B T} \ln \frac{4k_B T}{\hbar \omega e^{\gamma_E}} \left(\frac{2d}{\lambda} \frac{\sigma_n^N}{\sigma_n^S} g(\beta) e^{-\frac{\epsilon_0}{k_B T}} + e^{-\frac{\Delta_\infty}{k_B T}} \right)$$

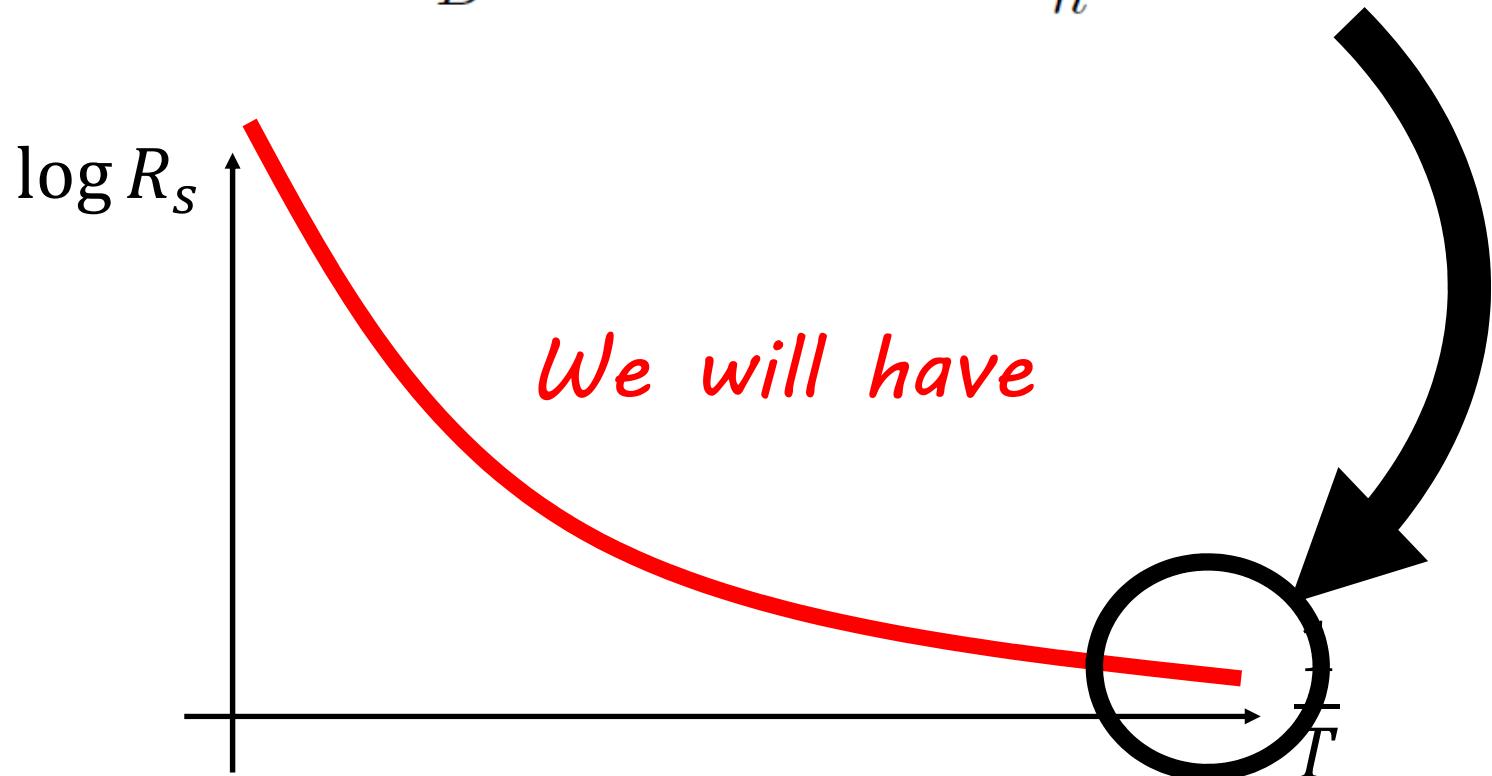
N layer contribution *Bulk S contribution*



Surface resistance

Approximate formula
(for $\alpha \ll 1$ and $\Gamma \rightarrow 0$)

$$R_i = \frac{1}{2} \mu_0^2 \omega^2 \lambda^3 \sigma_n^S \frac{4\Delta_\infty}{k_B T} \ln \frac{4k_B T}{\hbar \omega e^{\gamma_E}} \frac{d}{\lambda} \frac{\sigma_n^N}{\sigma_n^S} g(\beta, \epsilon_0) e^{-\frac{\epsilon_0}{k_B T}}$$

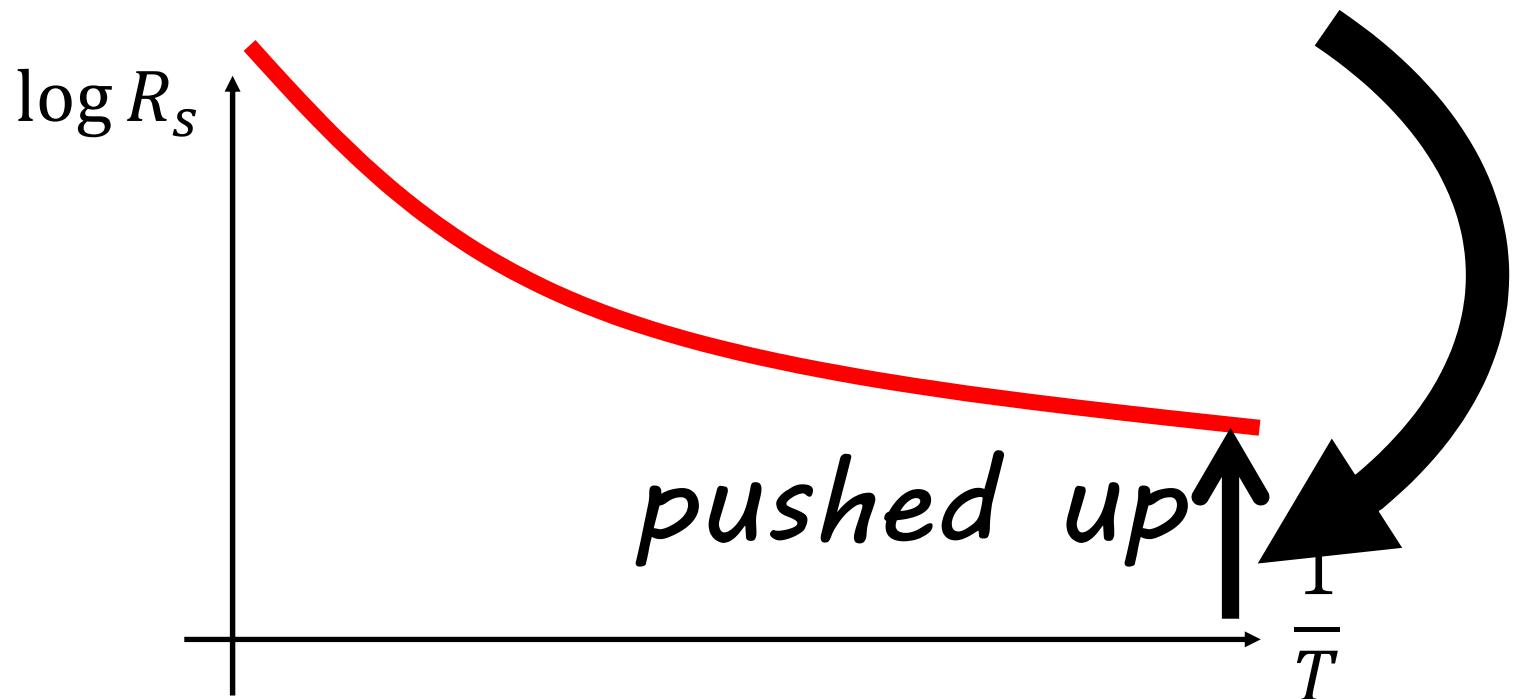


Surface resistance

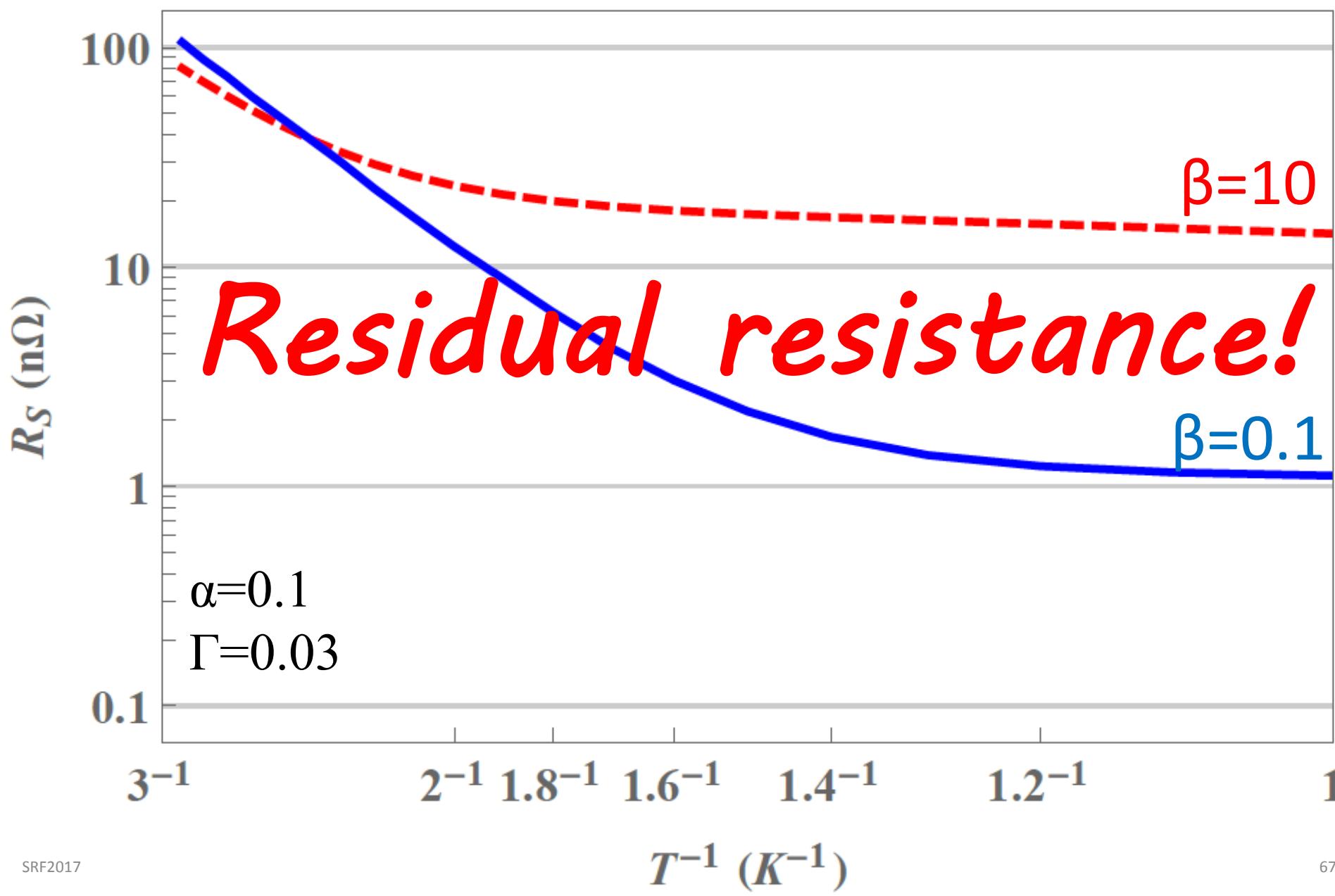
As the DOS broadening parameter increases, the subgap state contribution pushes up the residual resistance.

Approximate formula (for finite Γ)

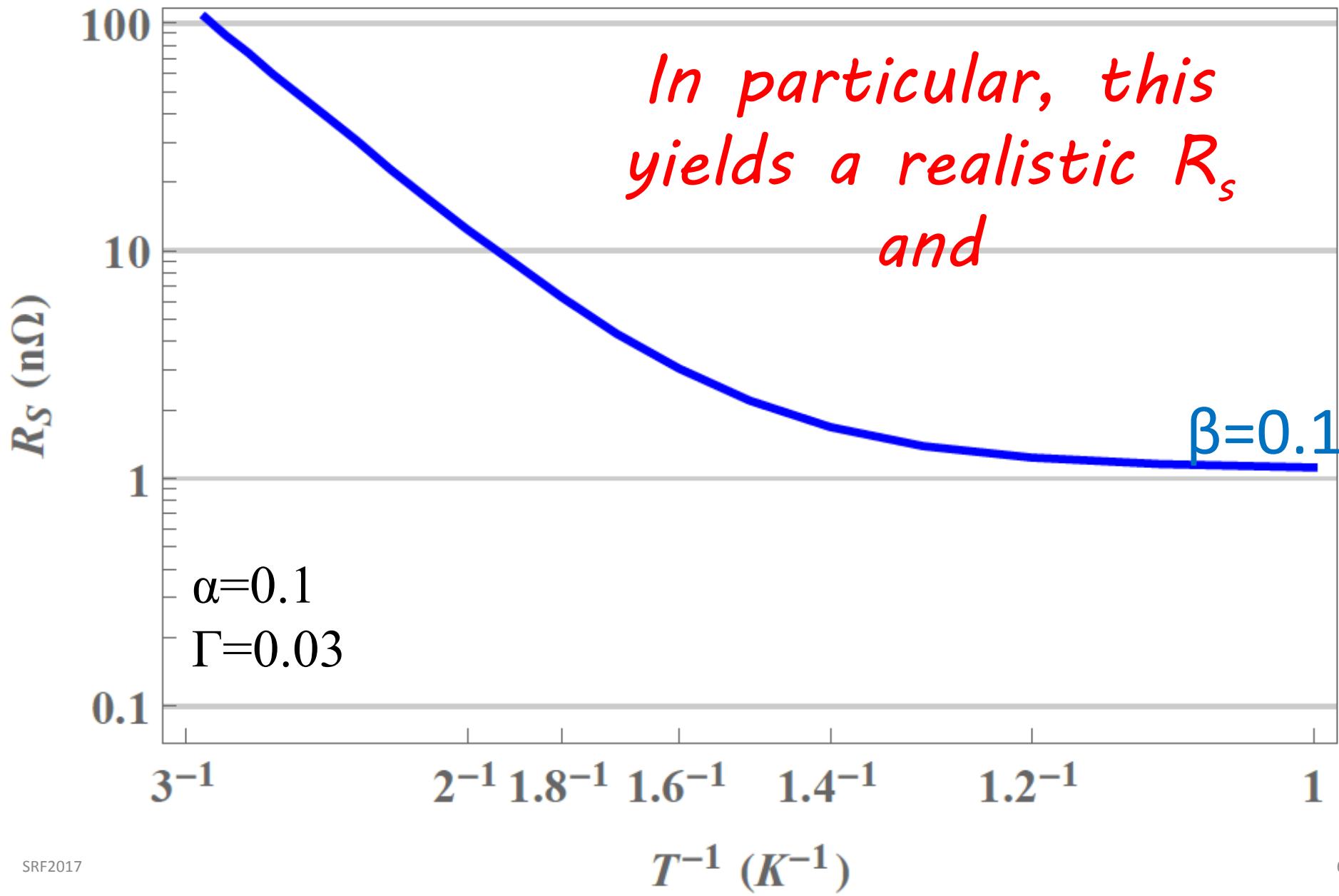
$$R_i = \frac{1}{2} \mu_0^2 \omega^2 \lambda^3 \sigma_n^S \frac{4k_B T}{\hbar \omega} \frac{\Gamma^2}{\Delta_\infty^2} \ln \frac{2}{1 + e^{-\hbar \omega / k_B T}} \left(\frac{d}{\lambda} \frac{\sigma_n^N}{\sigma_n^S} \frac{(1 + \beta \sqrt{1 + (\frac{\Gamma}{\Delta_\infty})^2})^2}{Z_\Gamma} + \frac{1}{2[1 + (\frac{\Gamma}{\Delta_\infty})^2]} \right)$$



Surface resistance: example

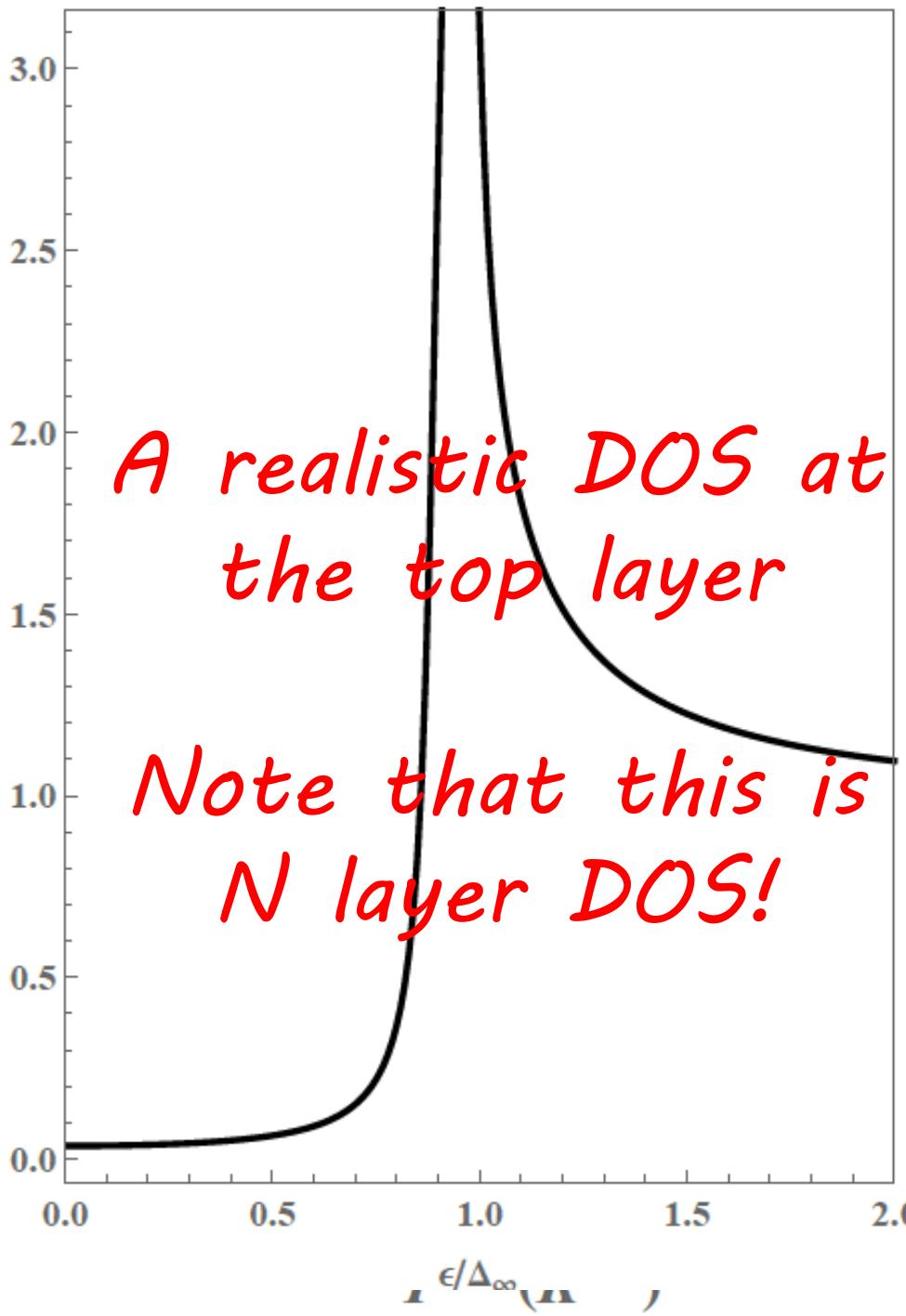
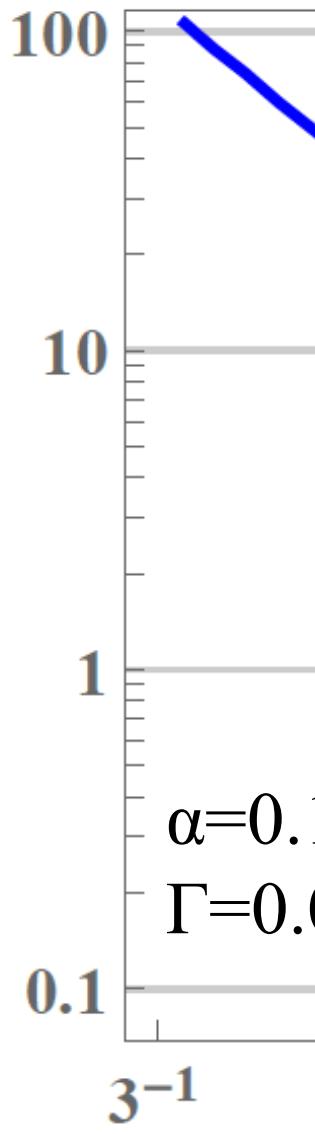


Surface resistance: example

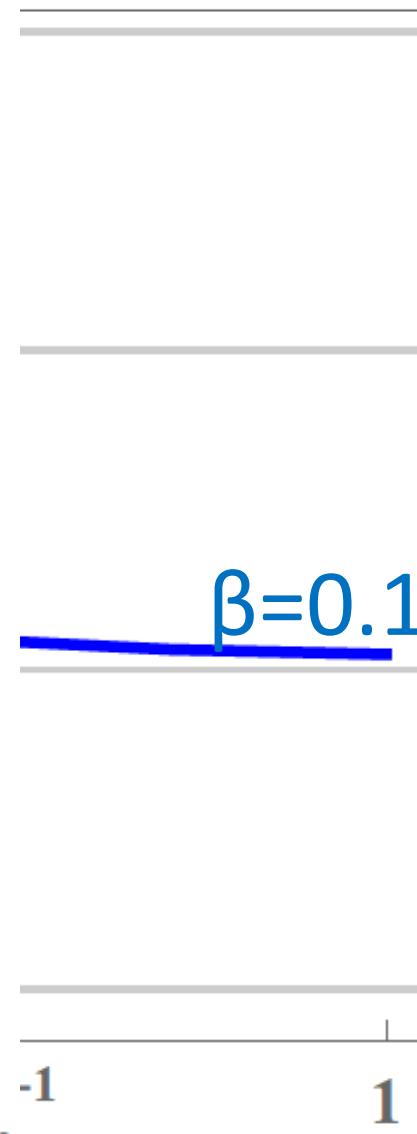


Surface

R_S (nΩ)



sample



*Probably
you are thinking*

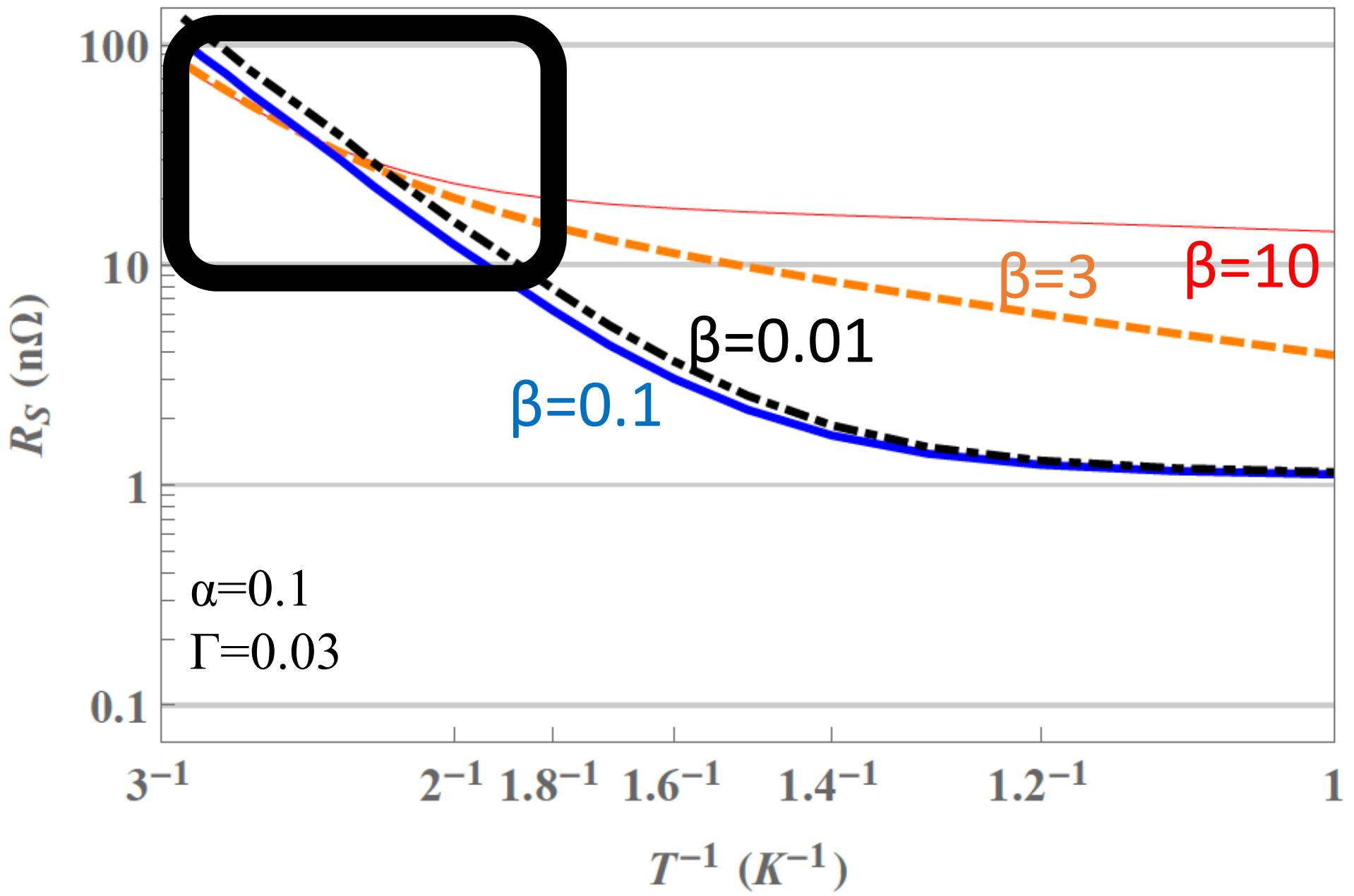
- OK, such a thin normal layer would exist and the DOS is broadened.
- Development of the theory with proximity coupled NS system with a finite density of subgap states is natural.
- The results seem to be nice.

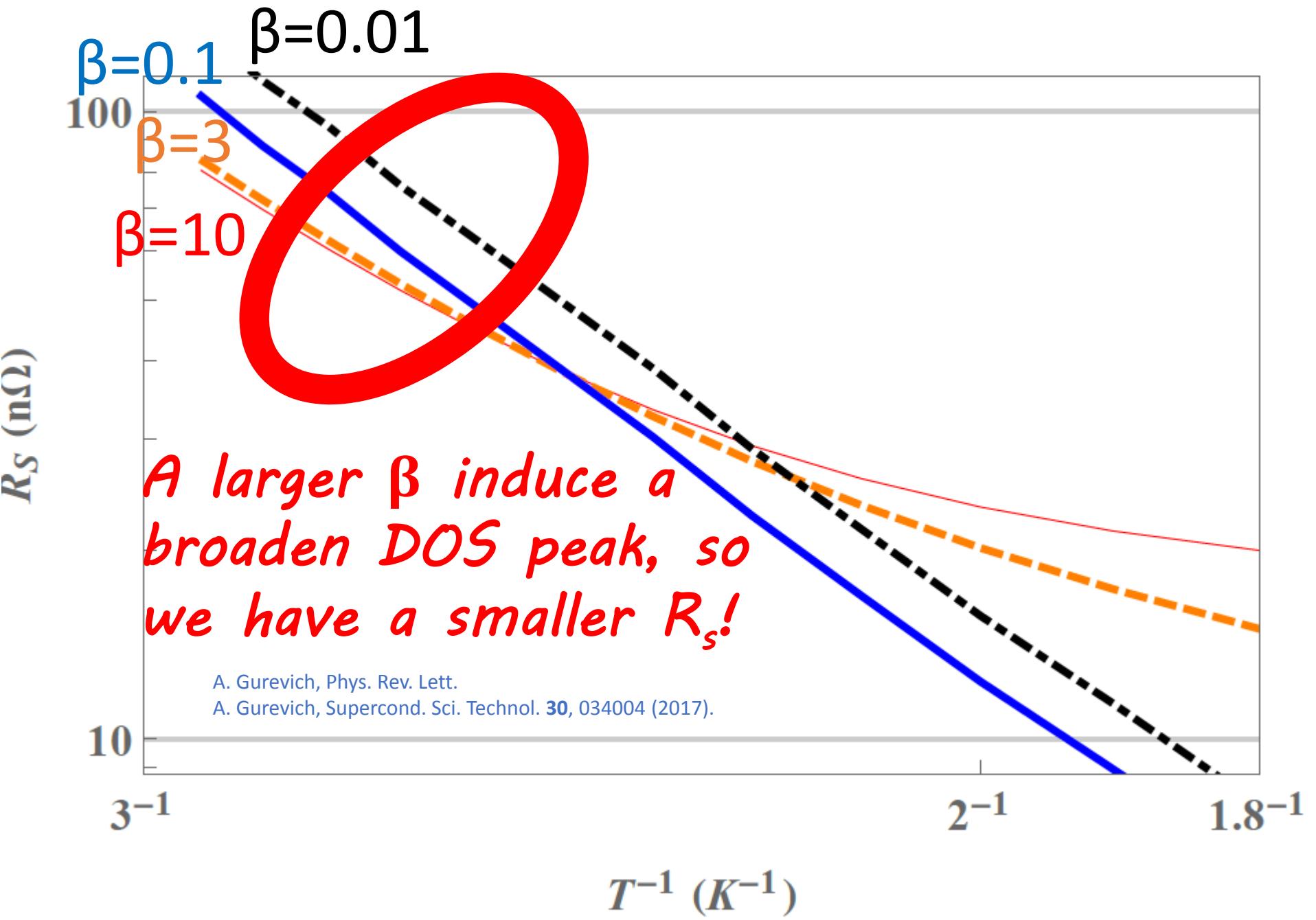
Then tell me

- how to confirm the theory by experiments?
- how to use the theory in order to improve Q_0 ?

Tune the surface layer
towards higher Q at 2K

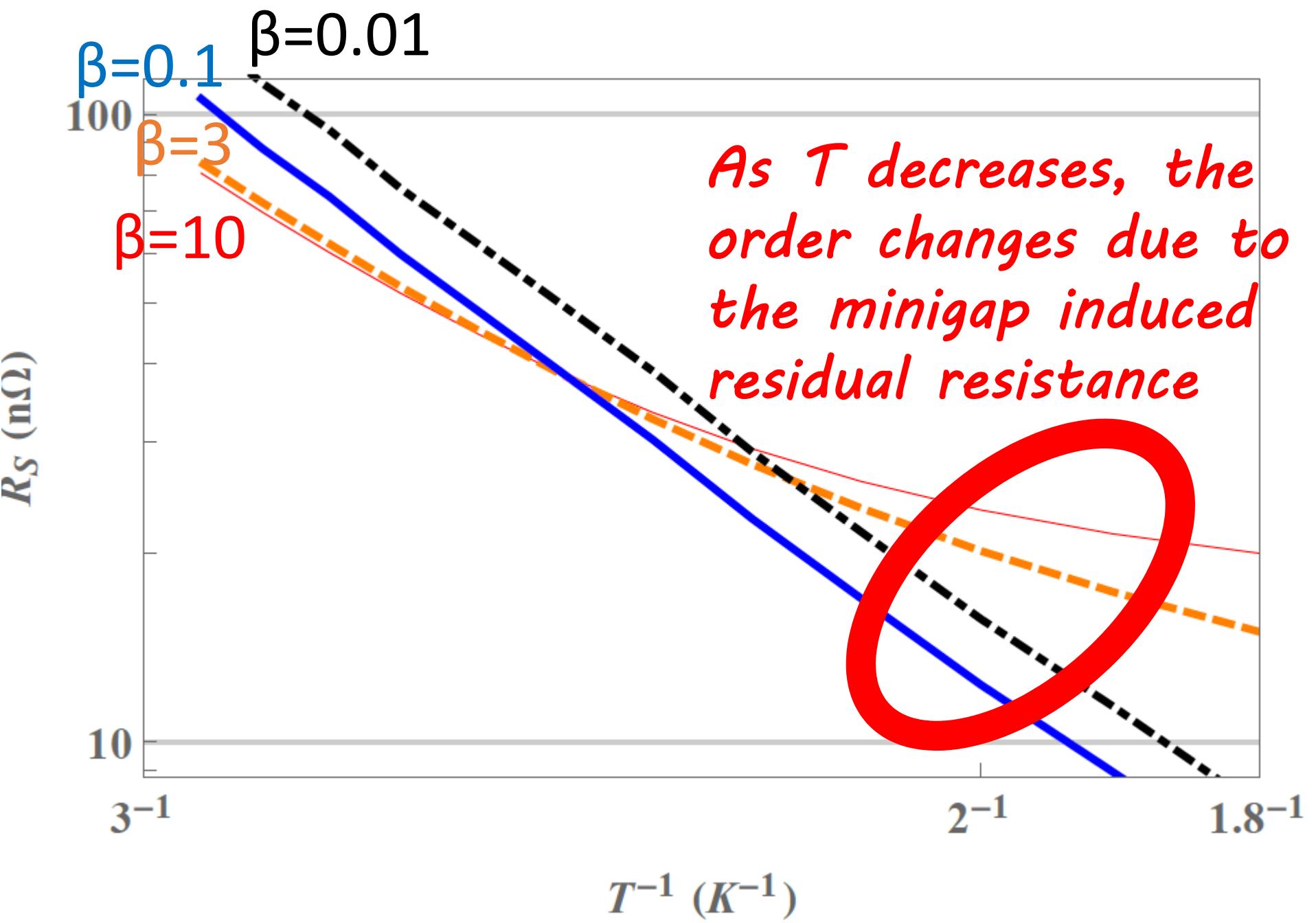
At $T \approx 2K$

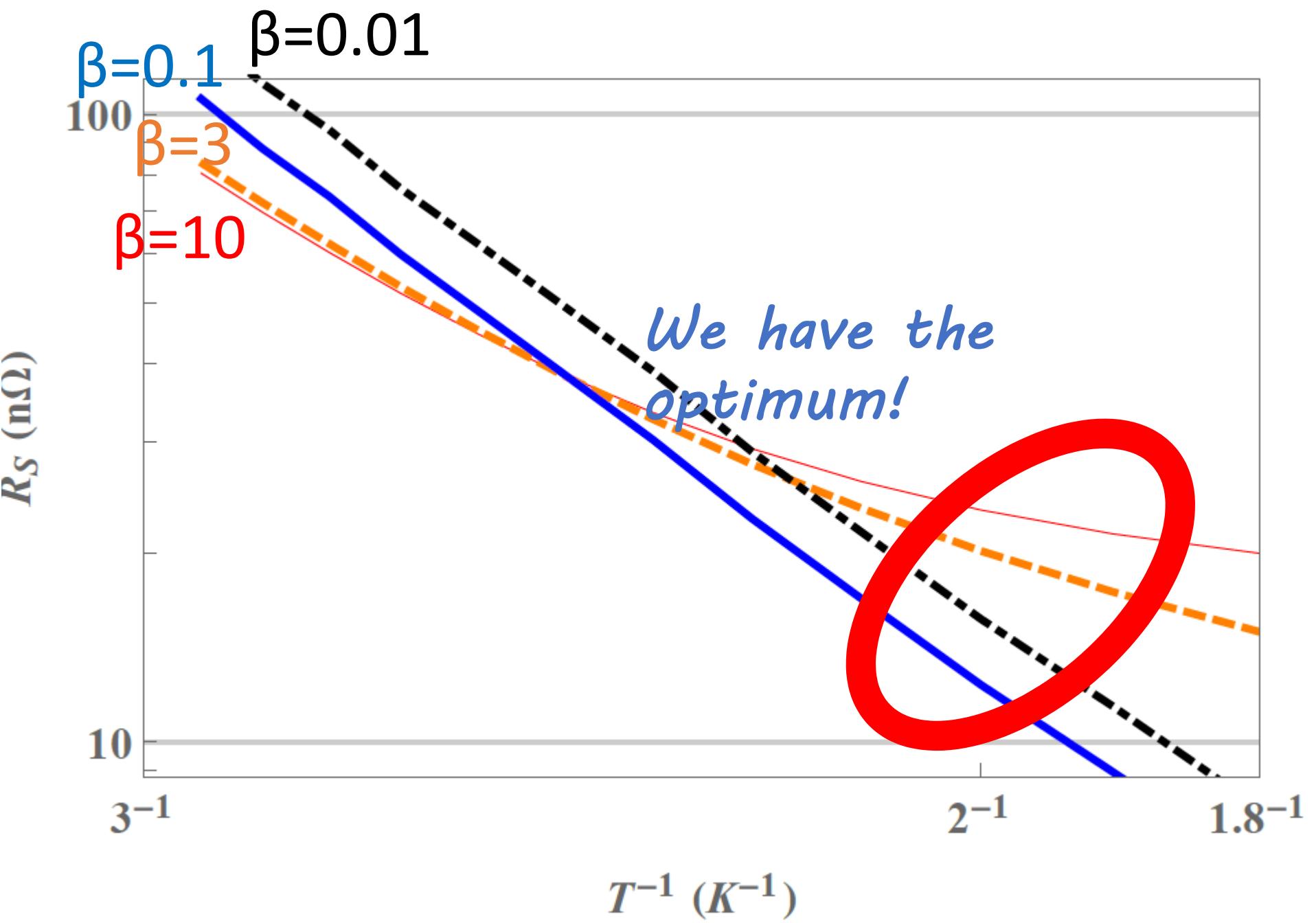




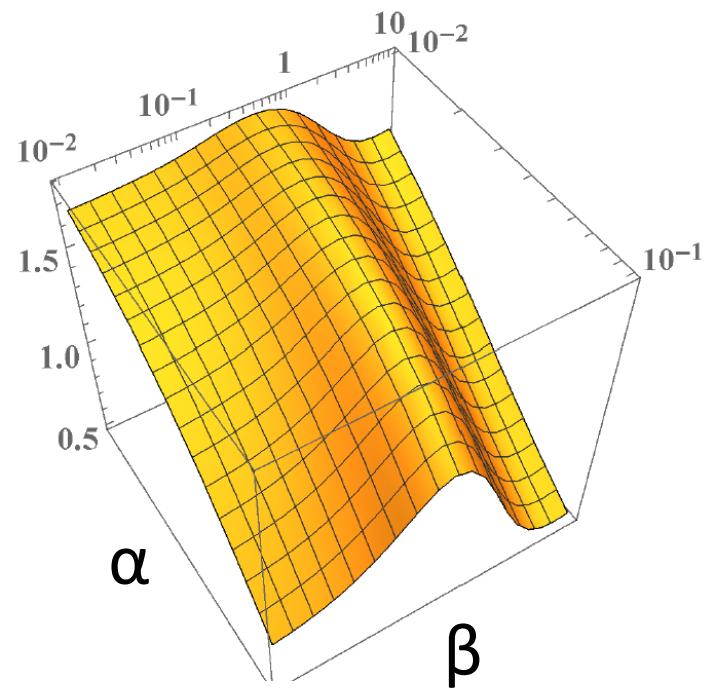
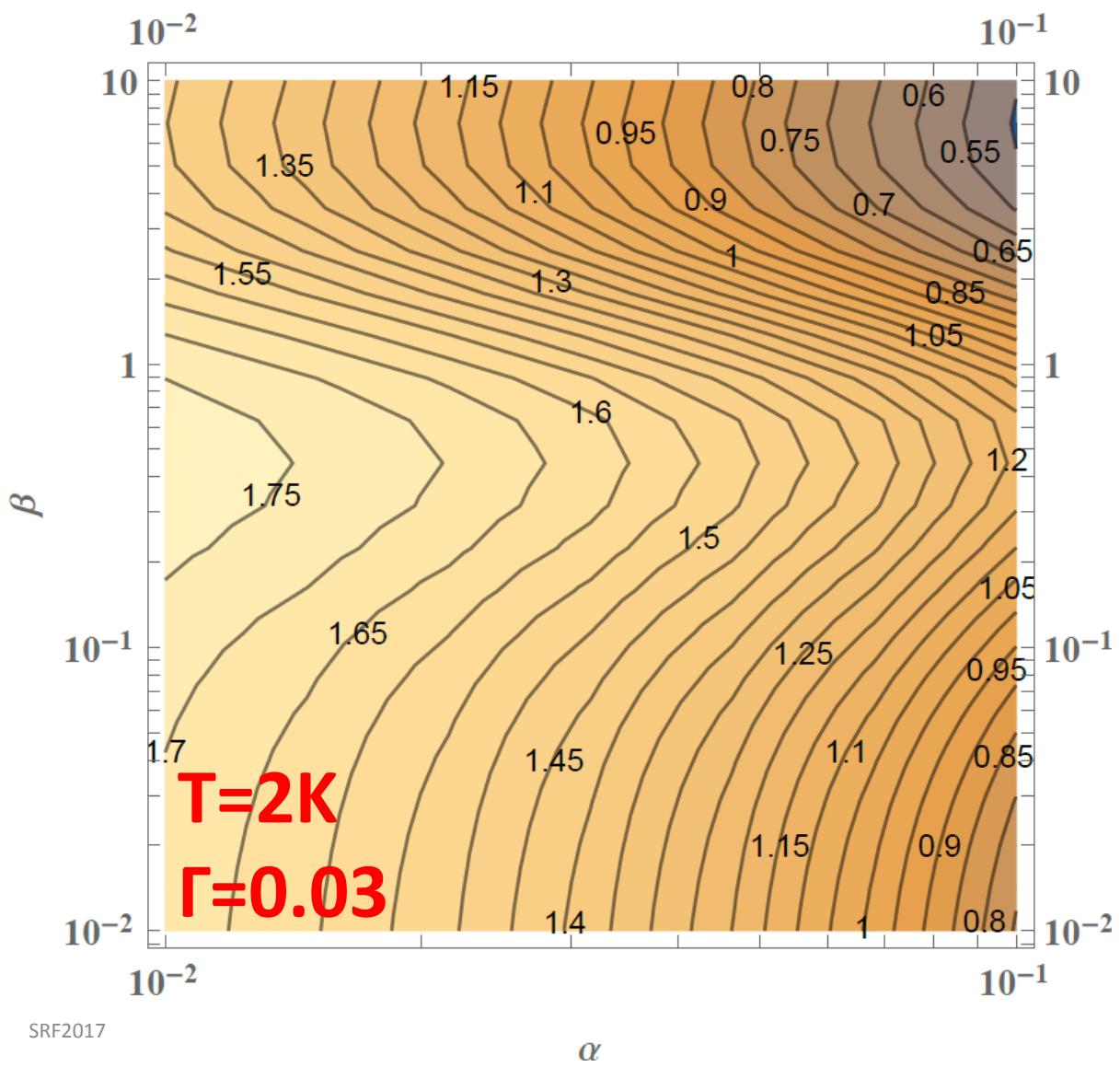
A. Gurevich, Phys. Rev. Lett.

A. Gurevich, Supercond. Sci. Technol. **30**, 034004 (2017).

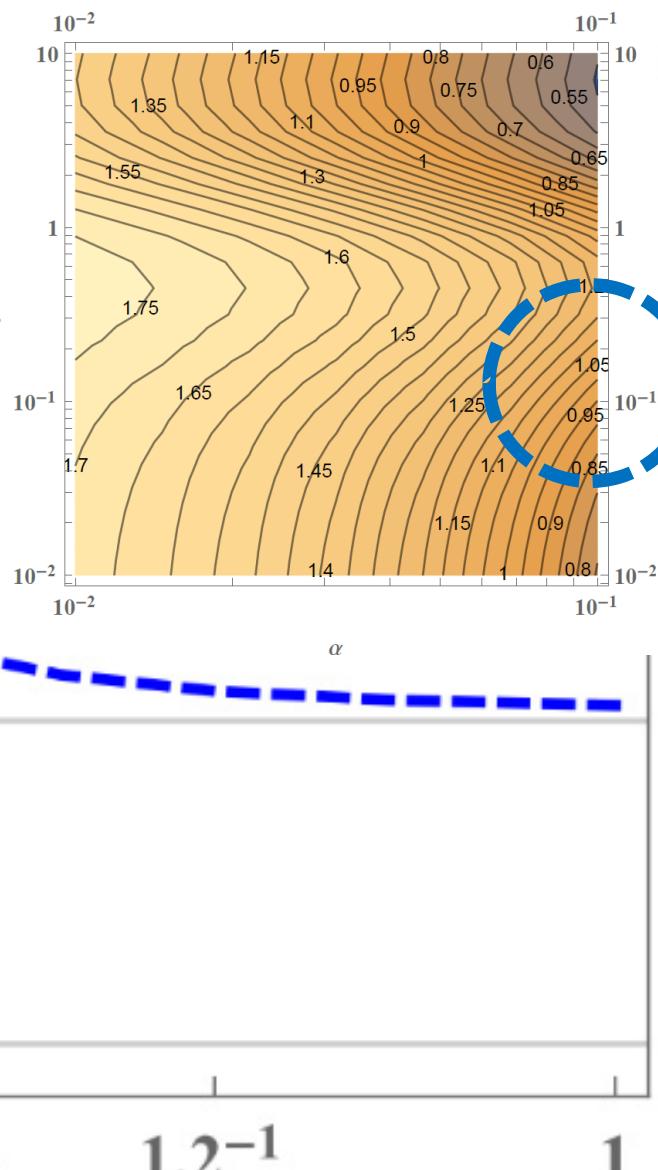
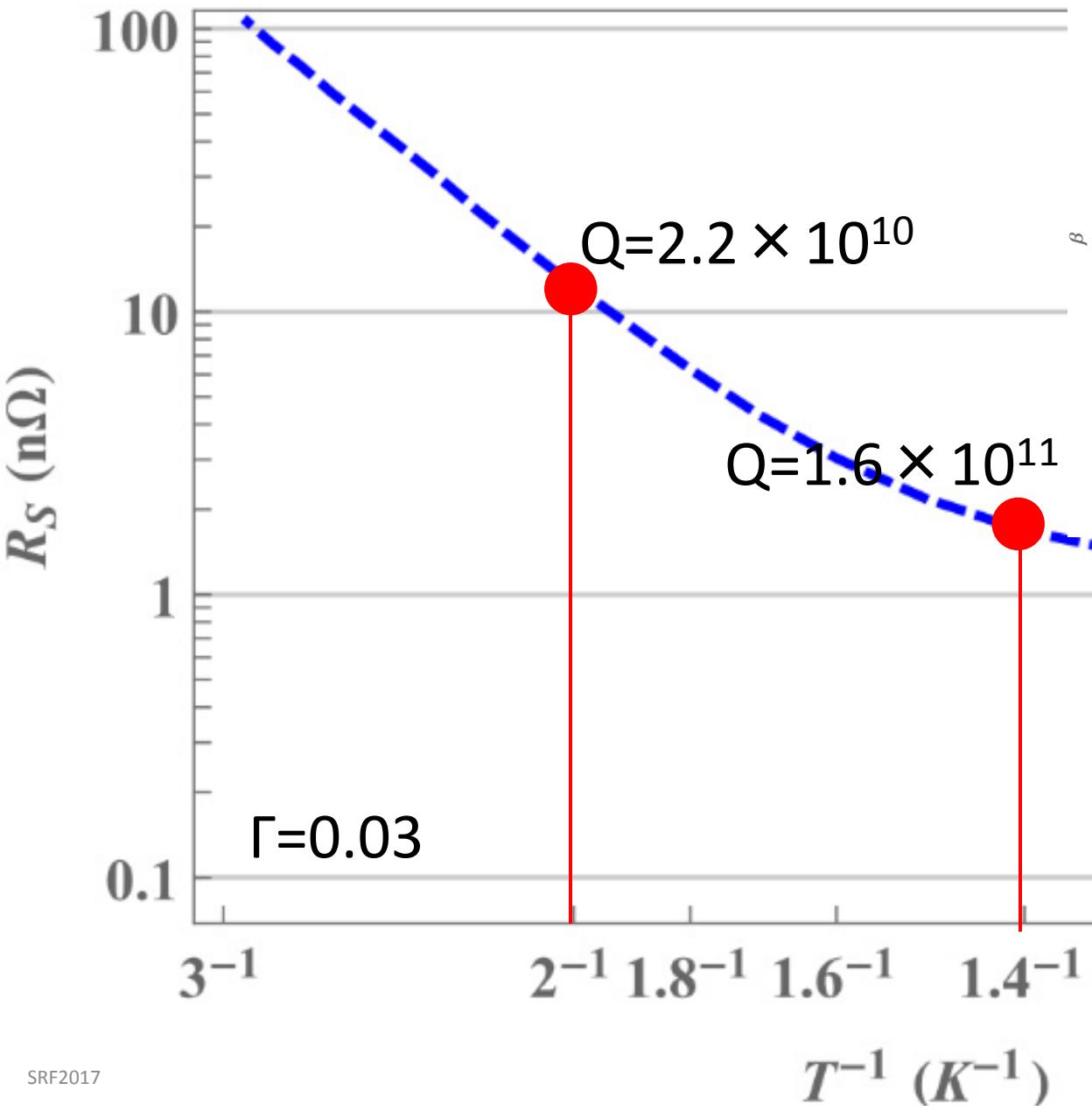




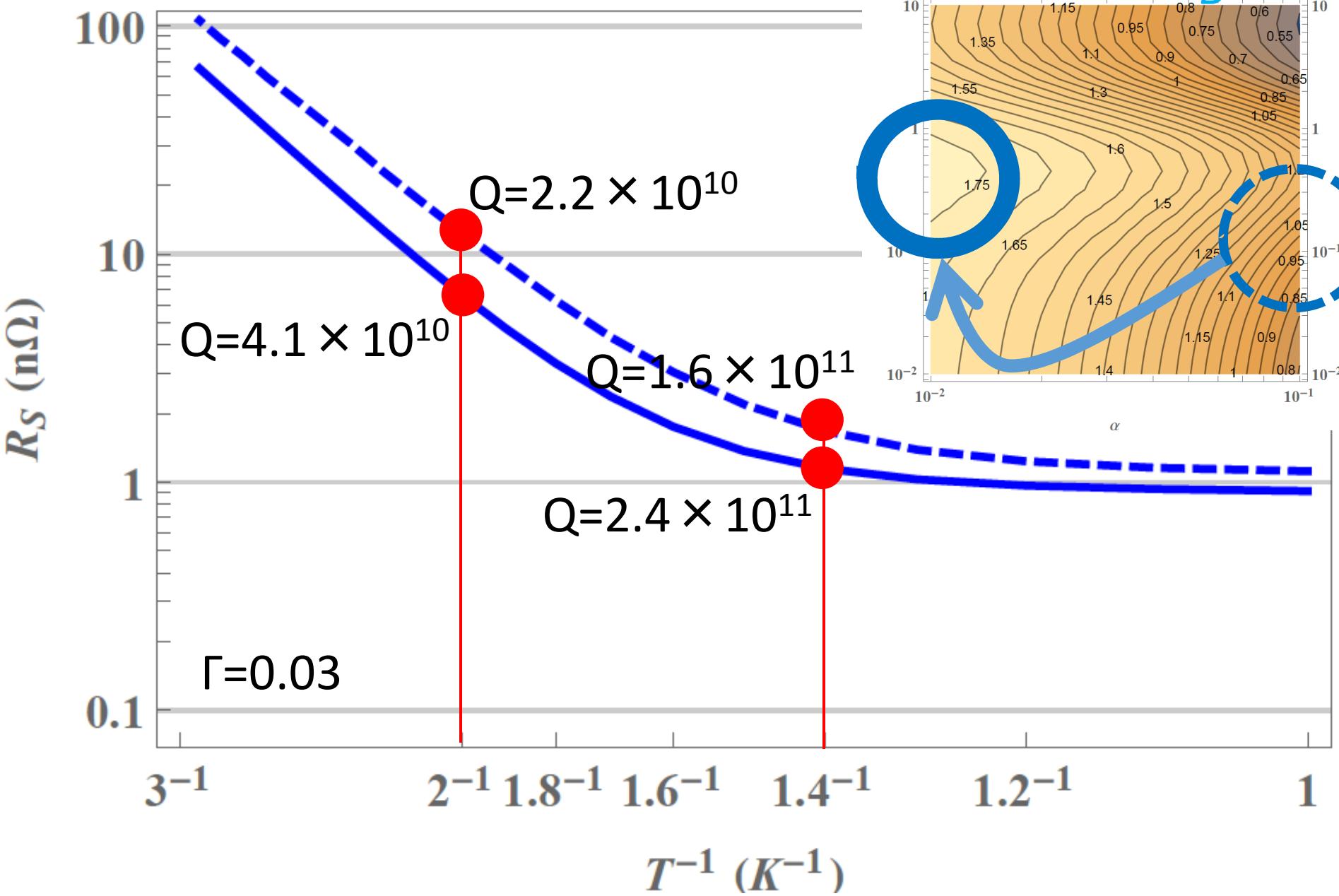
We can tune R_s
by varying α and β .



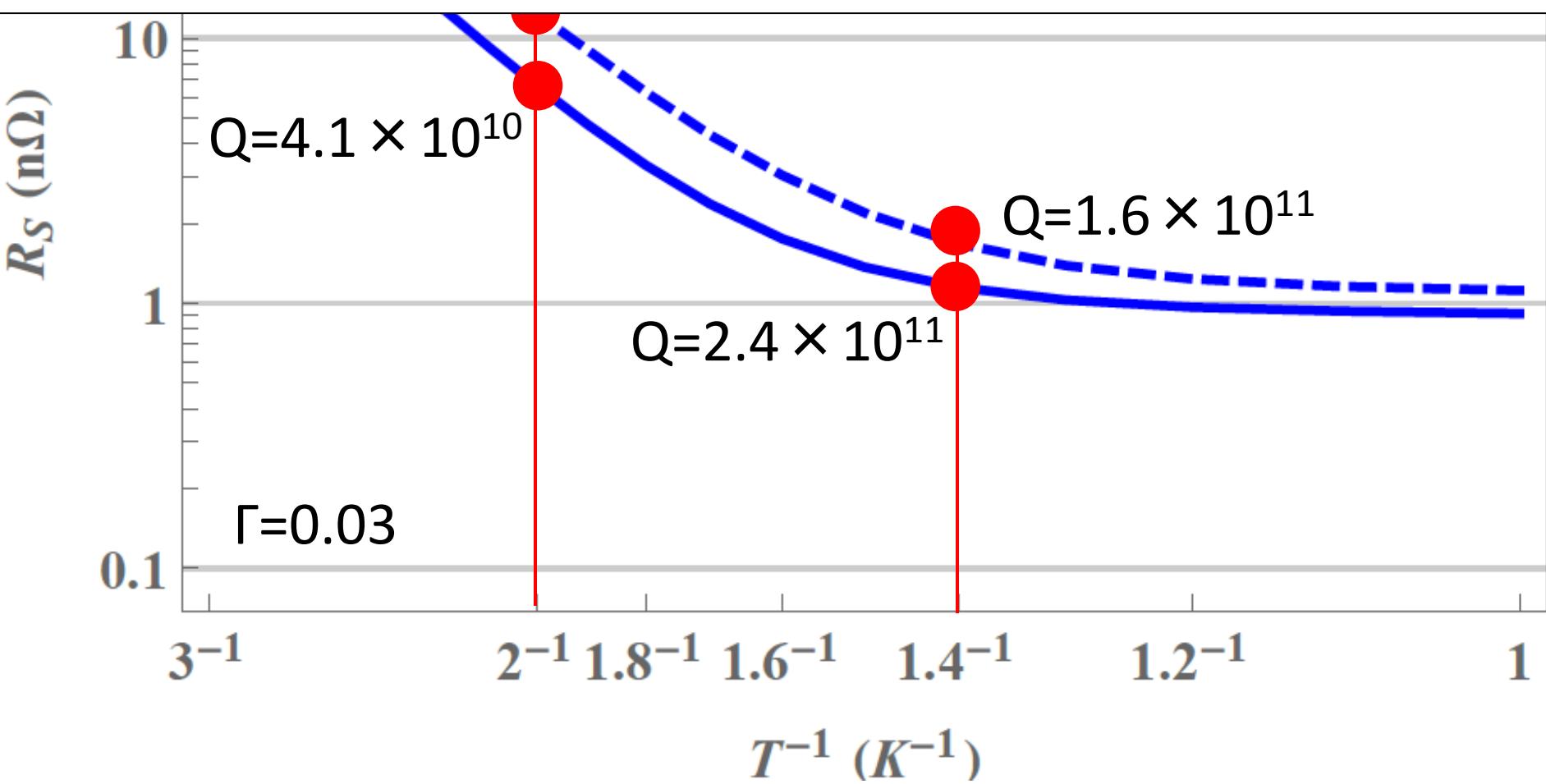
$$\frac{Q_0}{Q_0^{MB}} = \frac{R_{MB}}{R_s} = \frac{I_{MB}}{I_N + I_S}$$



Decreases N layer thickness d and increases the interface resistance R_B



The differences between the 2 curves are analogous to those between *ILC recipe* and *nitrogen dope!*
The low field R_s for different surface processing might be explained by *the normal layer thickness and interface resistance*.



Summary

- We developed a unified theory of surface resistance and residual resistance
- The theory incorporates the effects of the surface normal layer or damaged layer and mechanism which produce finite density of subgap states in the bulk.
- The theory incorporates both the conventional MB contribution and the residual resistance.
- The NS coupling affects not only residual resistance but also surface resistance at $T \sim 2K$.
- We showed it is possible to tune R_s by optimizing the thickness of metallic suboxide layer and the interface resistance.

Tune the surface!



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